

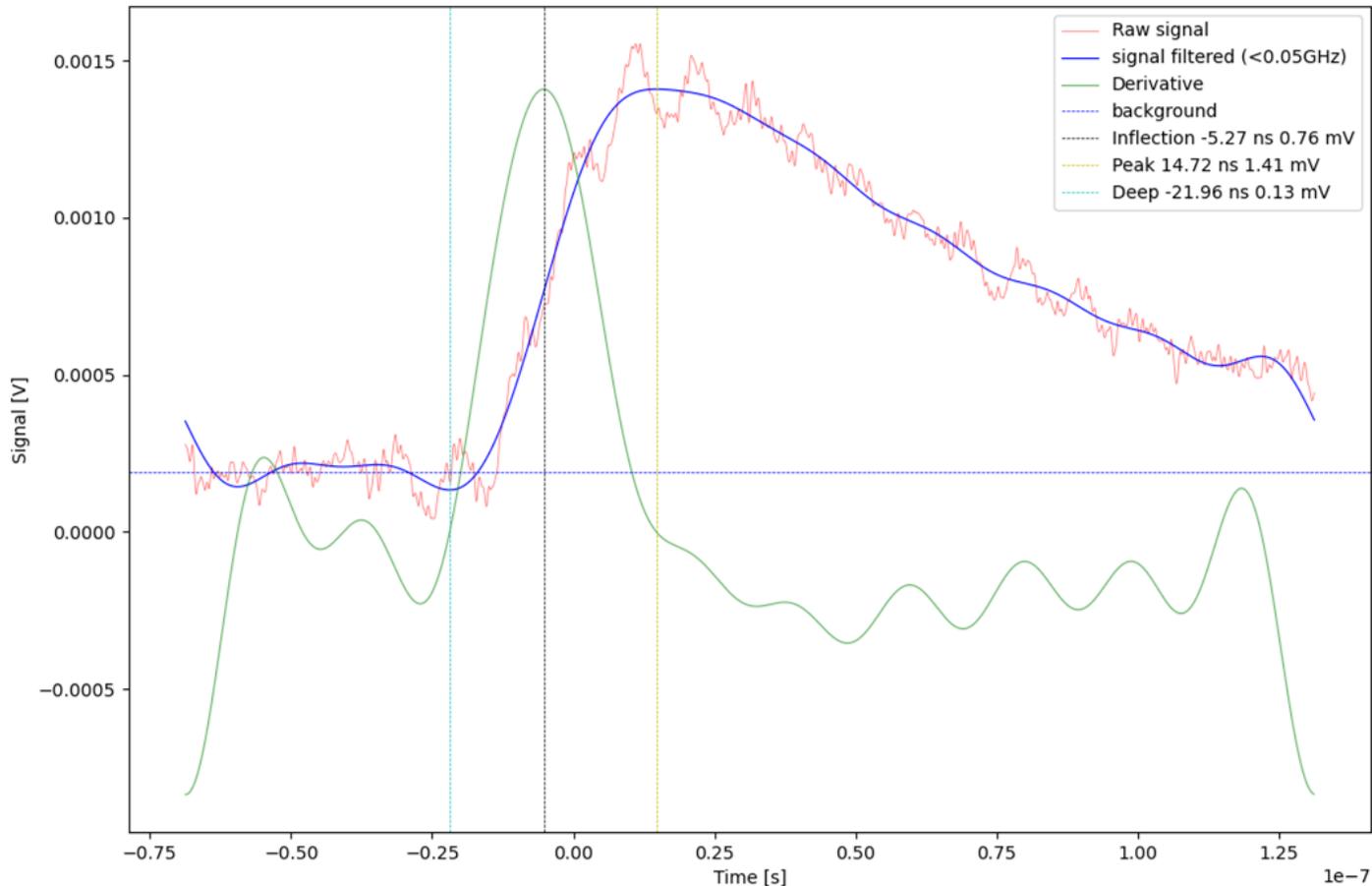
# Photon collection time simulation and comparison with laboratory data

---

Corrado Altomare, Roberta Pillera and Fabio Gargano

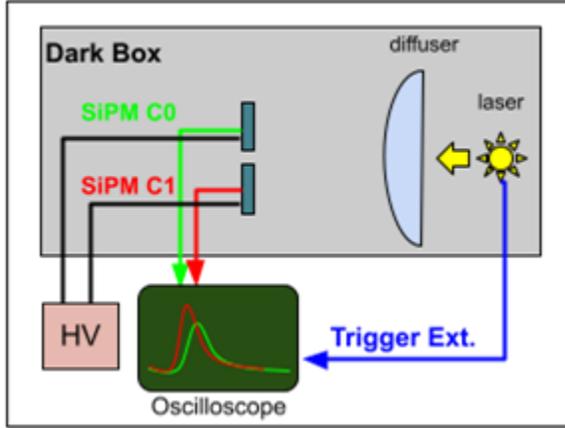
1/4/2022

# Time sampling: Analysis with derivative



- **Raw signal:** Waveform was acquired with the Oscilloscope
- **Signal filtered:** Waveform was filtered with Low-pass filter <50MHz
- **Derivative:** The filtered waveform was analyzed in its first derivative
- **Inflection:** Time was sample in the peak of the derivative; the inflection point of the signal (this value is very close to the 50% of the Signal amplitude)
- **Peak:** Is the first peak of the filtered function after the inflection
- **Deep:** Is the first deep of the filtered function before the inflection

# Lab Tests: Laser SetUp



Laser PiLas

Tune 50%

Pulsed 20 Hz

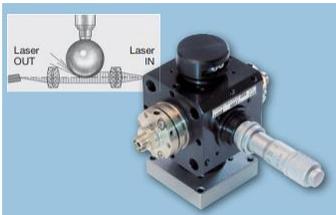
Diffuser thorlabs ED1-S50\_MD

Attenuation with pinhole 2.5 mm

Distance from device ~20 cm

Fiber QSMJ-3A3S-400-3/125-3-1

Length 1 m



Configuration 1)

C0 -> 1 X SiPM AdvanSid nuv 1x1 mm<sup>2</sup>

C1 -> 1 X SiPM AdvanSid nuv 1x1 mm<sup>2</sup>

DAQ: Oscilloscope R&S 6GHz 20GS

Trigger: External from laser

HV: 30.50 V (+2.5 OV)

Configuration 2)

C0 -> 1 X SiPM AdvanSid nuv 3x3 mm<sup>2</sup>

C1 -> 1 X SiPM AdvanSid nuv 3x3 mm<sup>2</sup>

DAQ: Oscilloscope R&S 6GHz 20GS

Trigger: External from laser

HV: 30.50 V (+2.5 OV)

Configuration 3)

C0 -> 3 X SiPM 3x3 mm<sup>2</sup> Hamamatsu OR S14160-1315 (Long pcb)

C1 -> 3 X SiPM 1x1 mm<sup>2</sup> Hamamatsu OR S14160-3015 (Long pcb)

DAQ: Oscilloscope LeCroy 1GHz 20GS

Trigger: External from laser

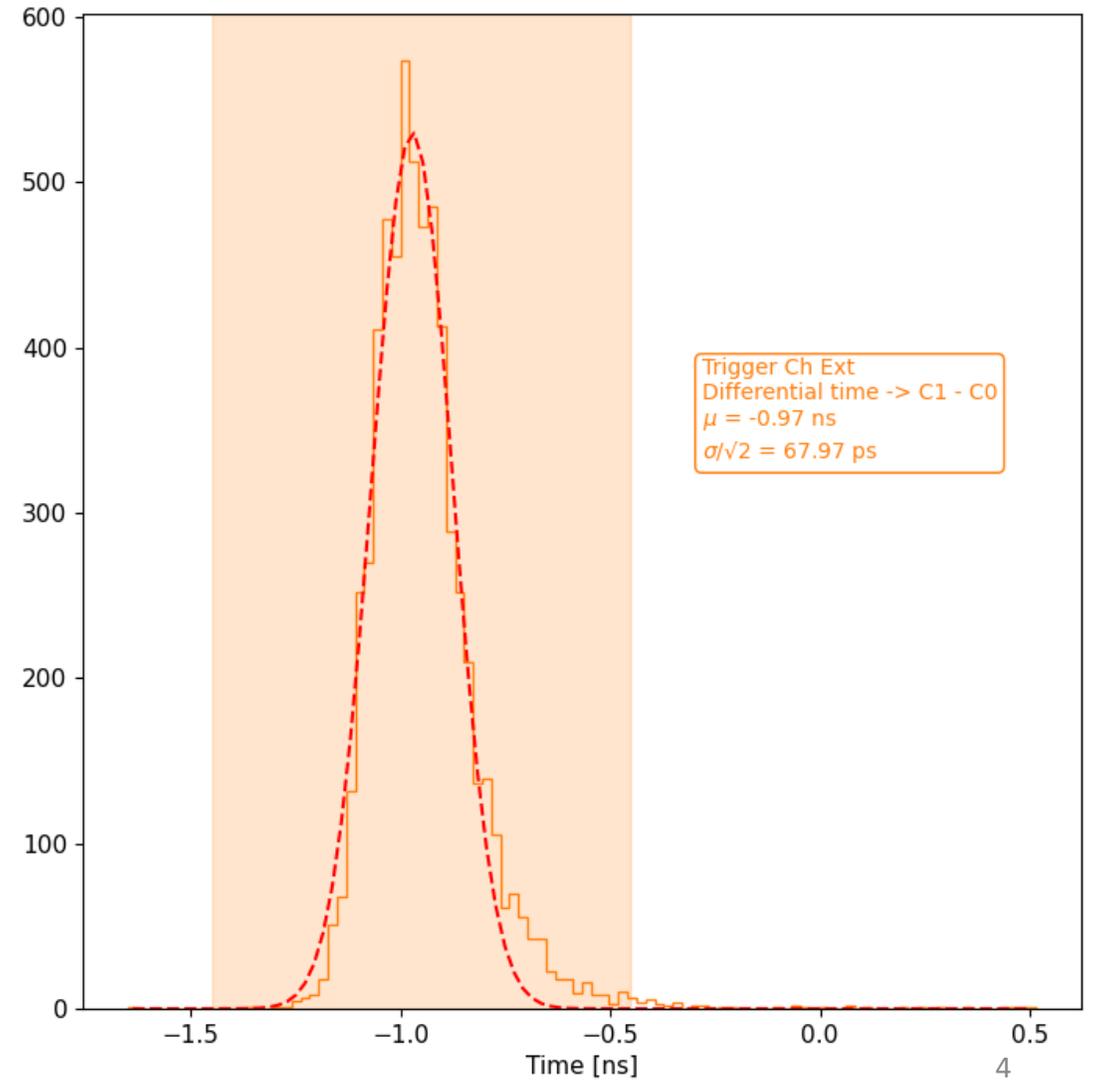
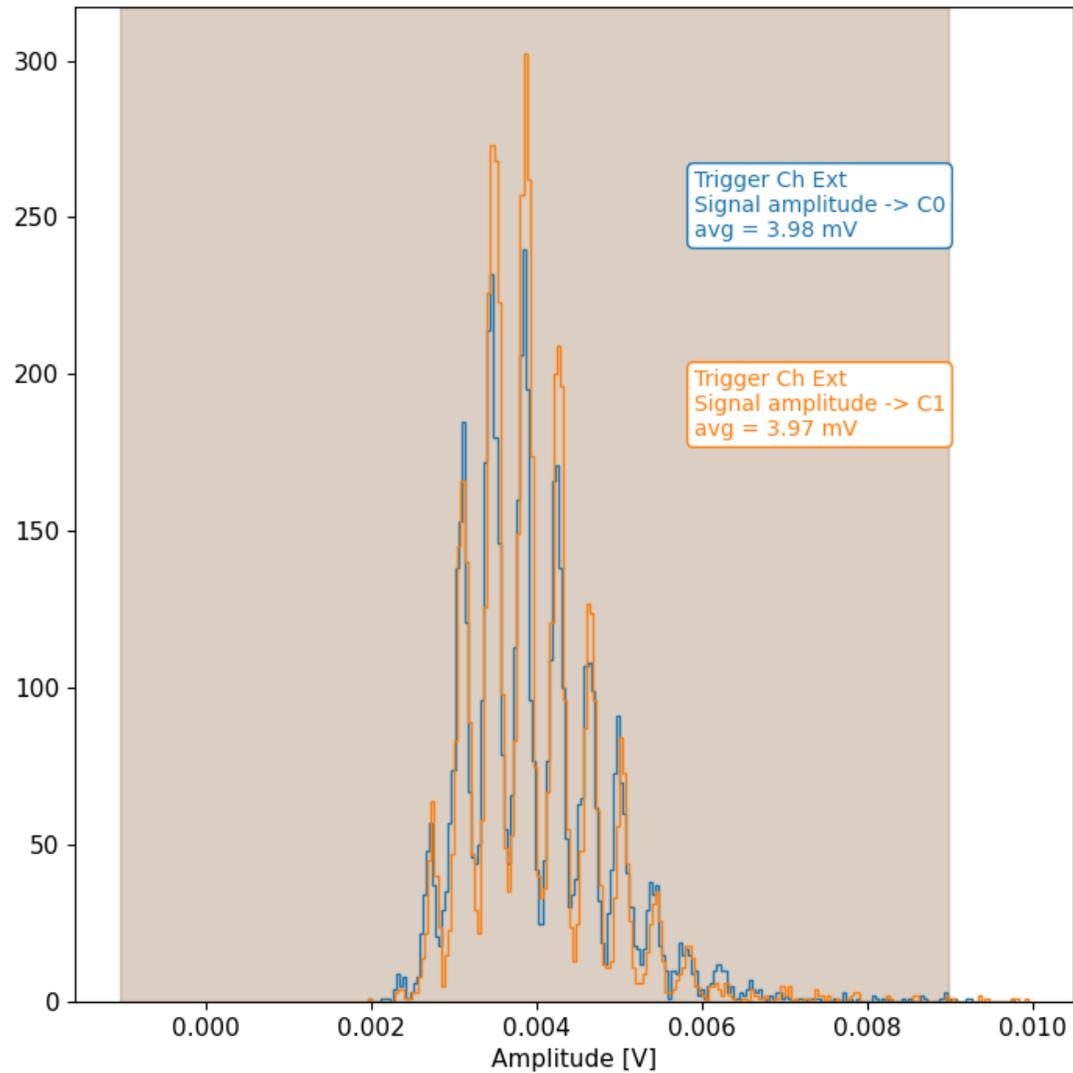
HV: 42.00 V (+4 OV)

# Lab Tests: Laser SetUp -> AdvanSiD 1x1 mm<sup>2</sup>

- Laser Source SiPM AdvanSiD 1x1 nuv - 30.5 HV - Amplitude distribution

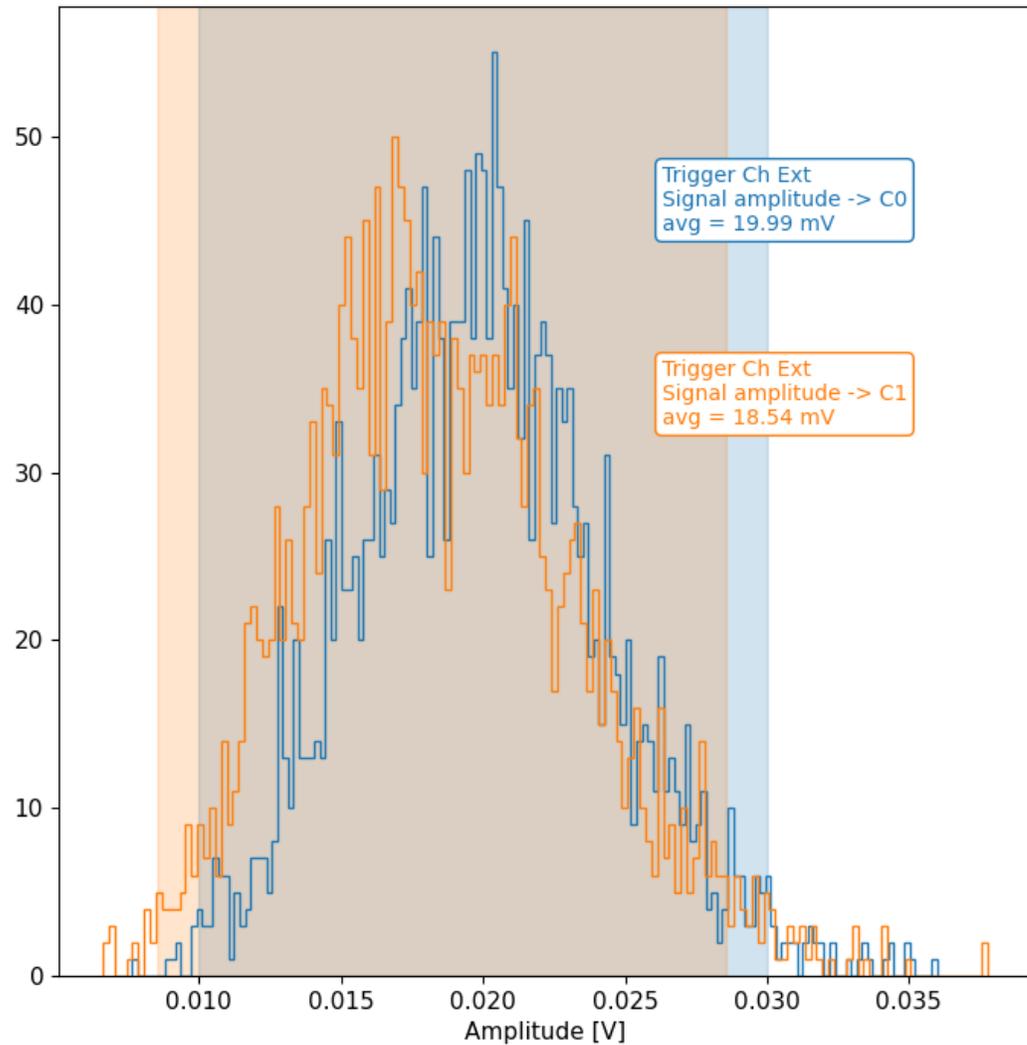
- Laser Source SiPM AdvanSiD 1x1 nuv - 30.5 HV - Inflection position

## Configuration 1



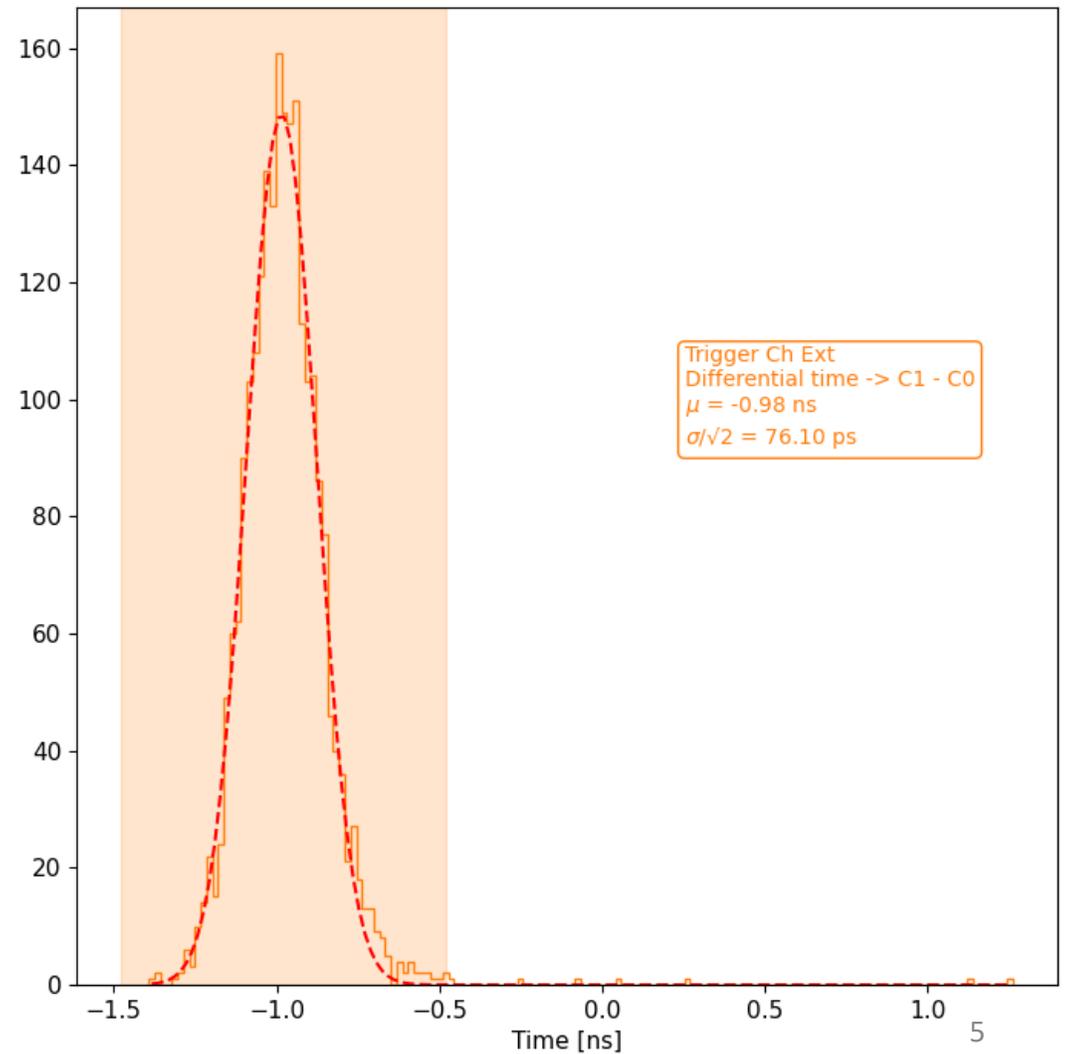
# Lab Tests: Laser SetUp -> AdvanSiD 3x3 mm<sup>2</sup>

- Laser Source SiPM AdvanSiD 3x3 nuv - 30.5 HV - Amplitude distribution



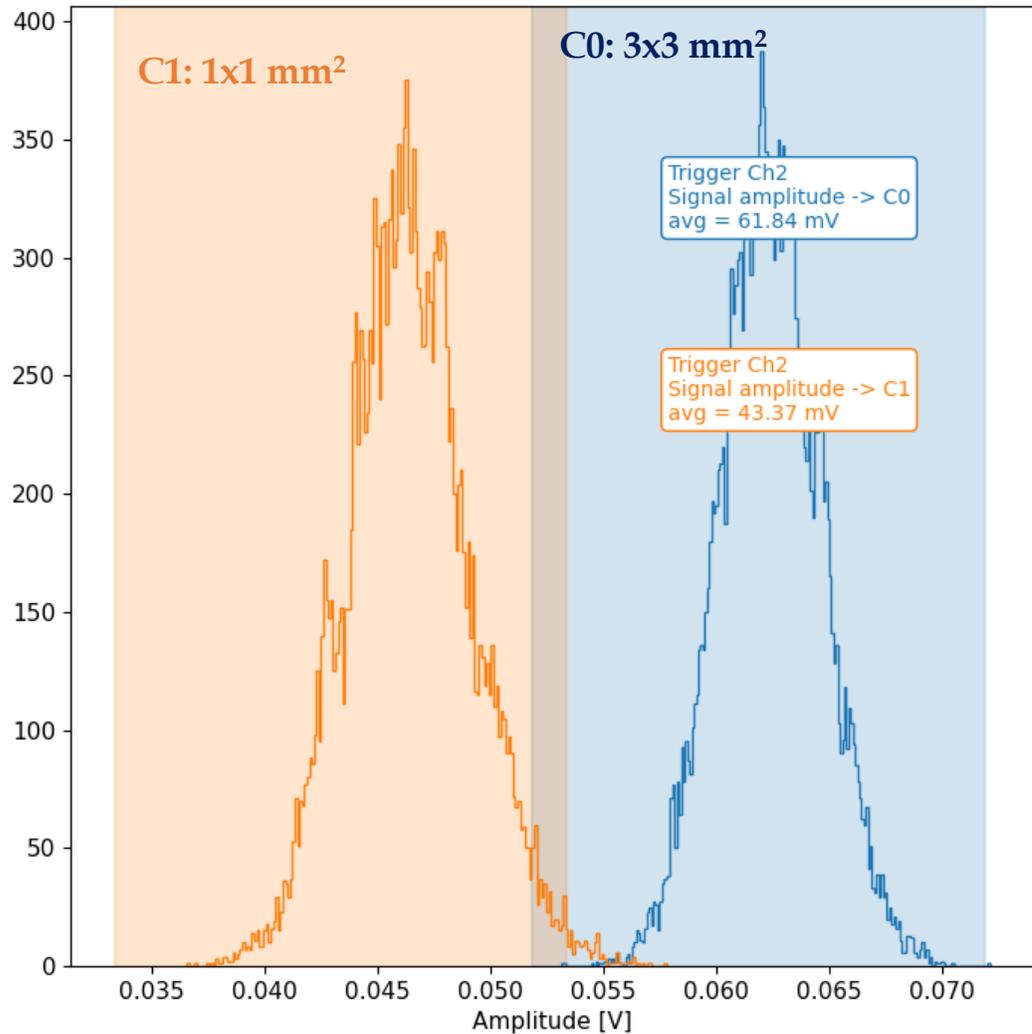
- Laser Source SiPM AdvanSiD 3x3 nuv - 30.5 HV - Inflection position

## Configuration 2



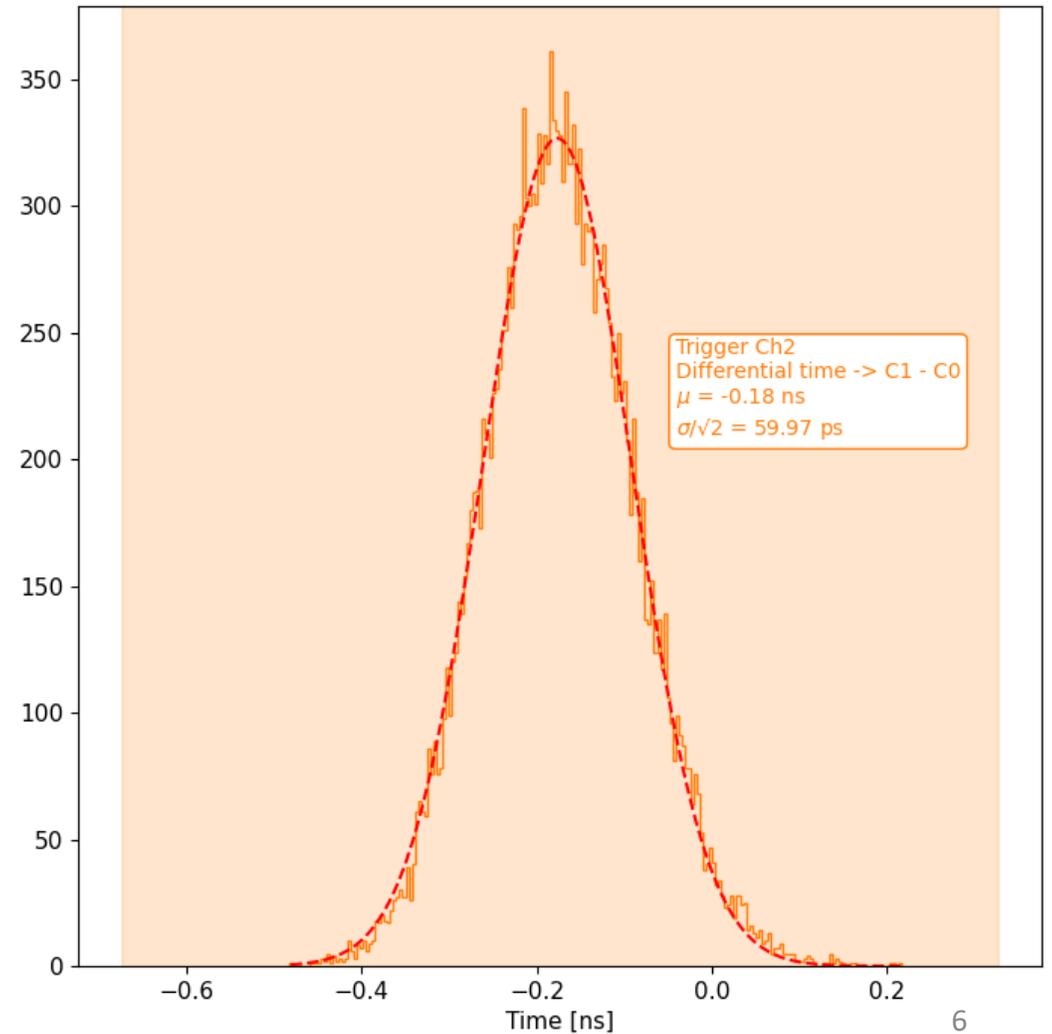
# Lab Tests: Laser SetUp -> Hamamatsu pcb 3x 1x1 mm<sup>2</sup> and 3x 3x3 mm<sup>2</sup>

- Laser Source SiPM Hamamatsu 3x3 - 42.0 HV - Amplitude distribution



- Laser Source SiPM Hamamatsu 3x3 - 42.0 HV - Inflection position

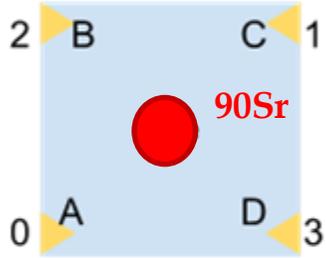
## Configuration 3



# Lab Tests: Results for laser configuration

Source	SiPM	Size	HV	$\sigma/\sqrt{2}$ [ps]
Laser	AdvanSiD	1 X 1x1 mm <sup>2</sup>	30.50	68
Laser	AdvanSiD	1 X 3x3 mm <sup>2</sup>	30.50	76
Laser	Hamamatsu	3 X 1x1 mm <sup>2</sup> Vs 3 X 3x3 mm <sup>2</sup>	42.00	60

# Lab Tests: $^{90}\text{Sr}$ SetUp



## Configuration 4)

C0 -> 1 X SiPM AdvanSiD nuv  $3 \times 3 \text{ mm}^2$

C1 -> 1 X SiPM AdvanSiD nuv  $3 \times 3 \text{ mm}^2$

C2 -> 1 X SiPM AdvanSiD nuv  $3 \times 3 \text{ mm}^2$

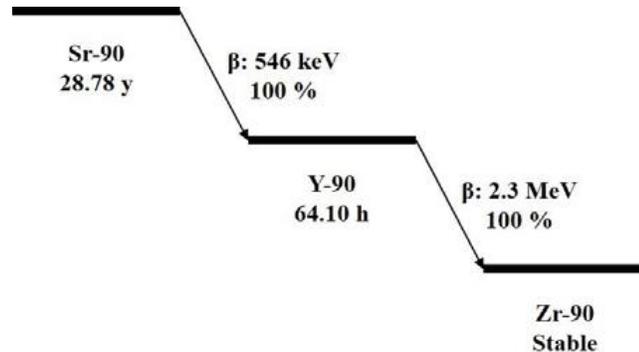
C3 -> 1 X SiPM AdvanSiD nuv  $3 \times 3 \text{ mm}^2$

DAQ: Oscilloscope LeCroy 1GHz 20GS

Trigger: C0 (Threshold 67mV)

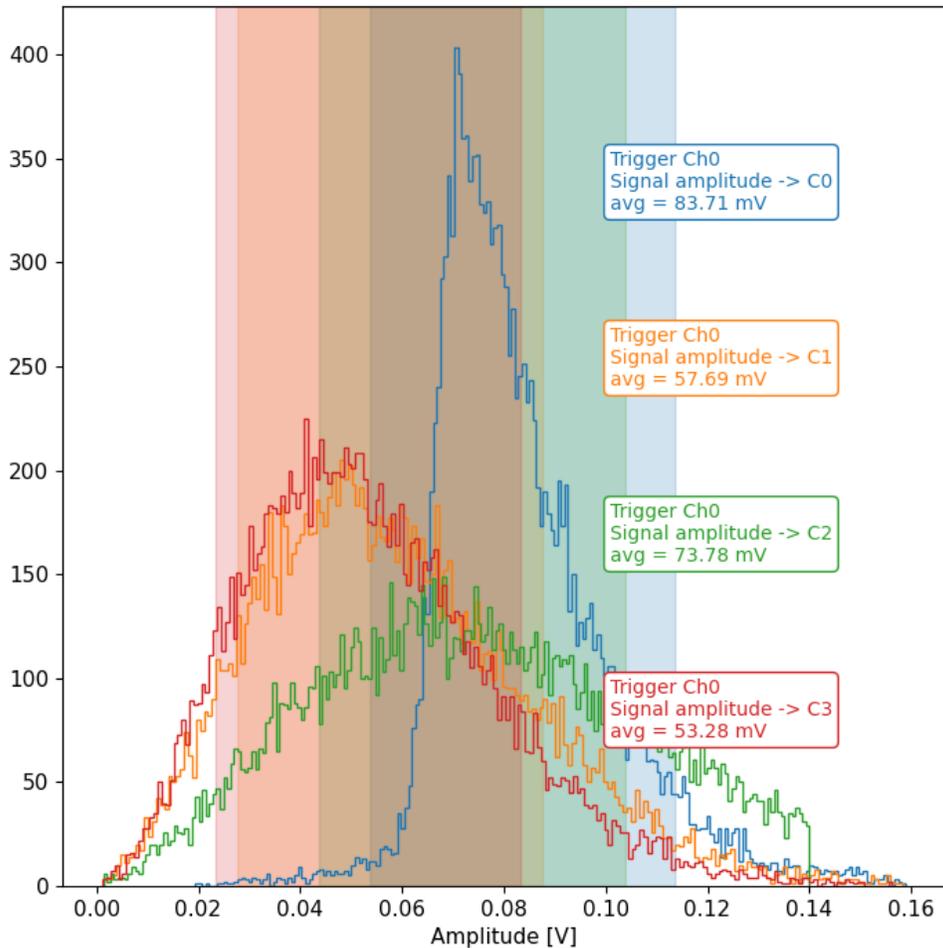
HV: 32.00 V (+4 OV)

$^{90}\text{Sr}$  Source  
2 MBq



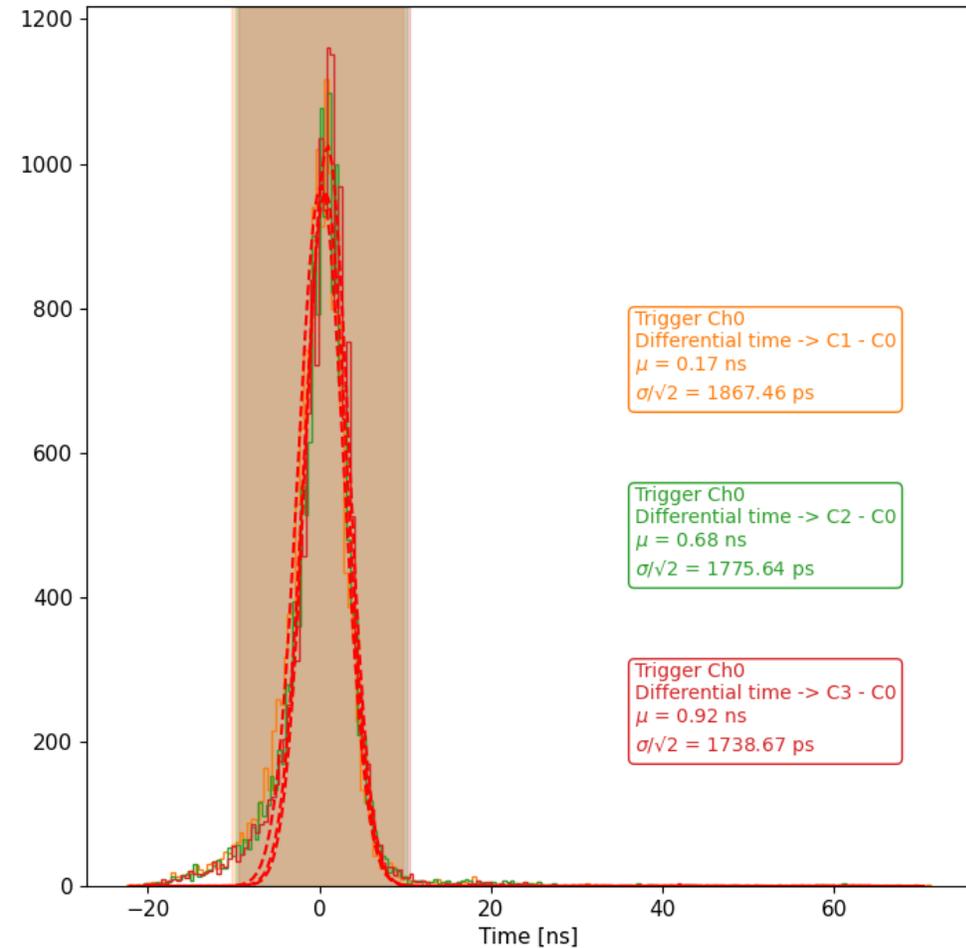
# Lab Tests: $^{90}\text{Sr}$ SetUp -> Advansid $3\times 3\text{ mm}^2$

-  $^{90}\text{Sr}$  Source SiPM AdvanSiD - 32.0 HV - Amplitude distribution



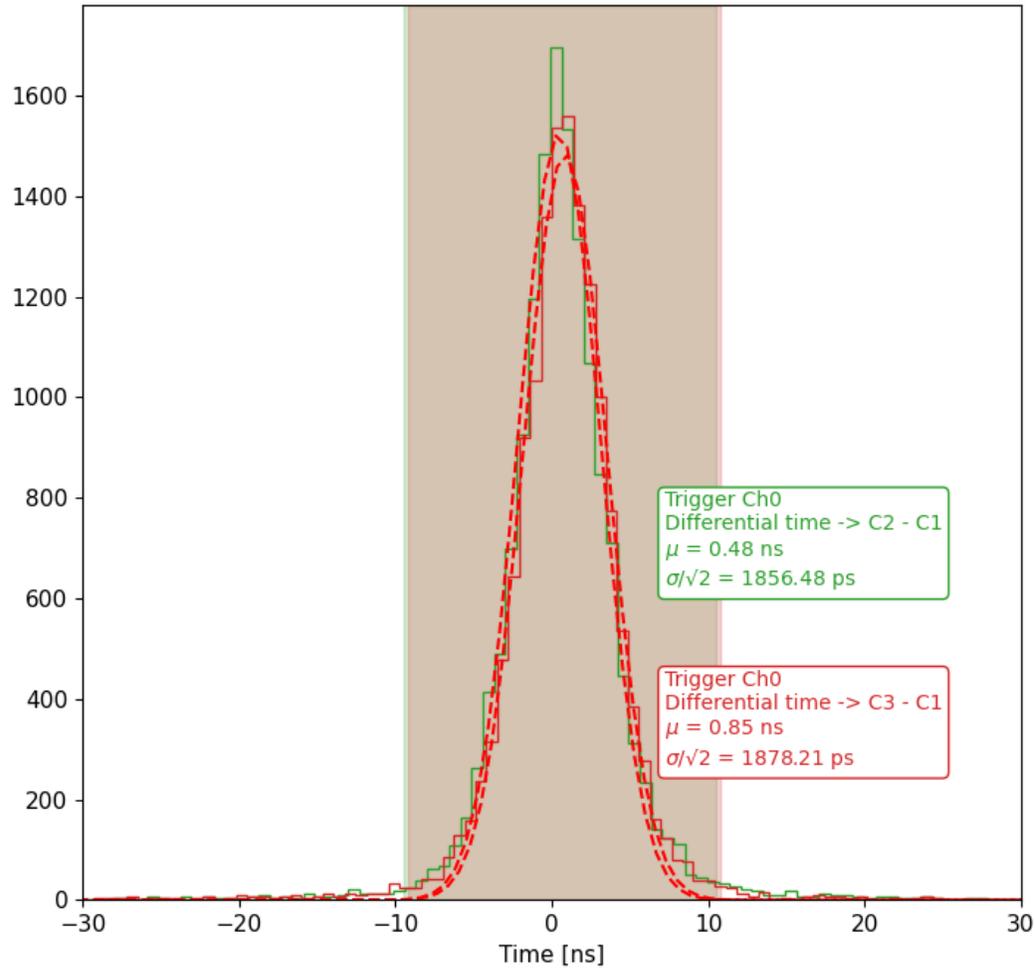
## Configuration 4

-  $^{90}\text{Sr}$  Source SiPM AdvanSiD - 32.0 HV - Inflection position



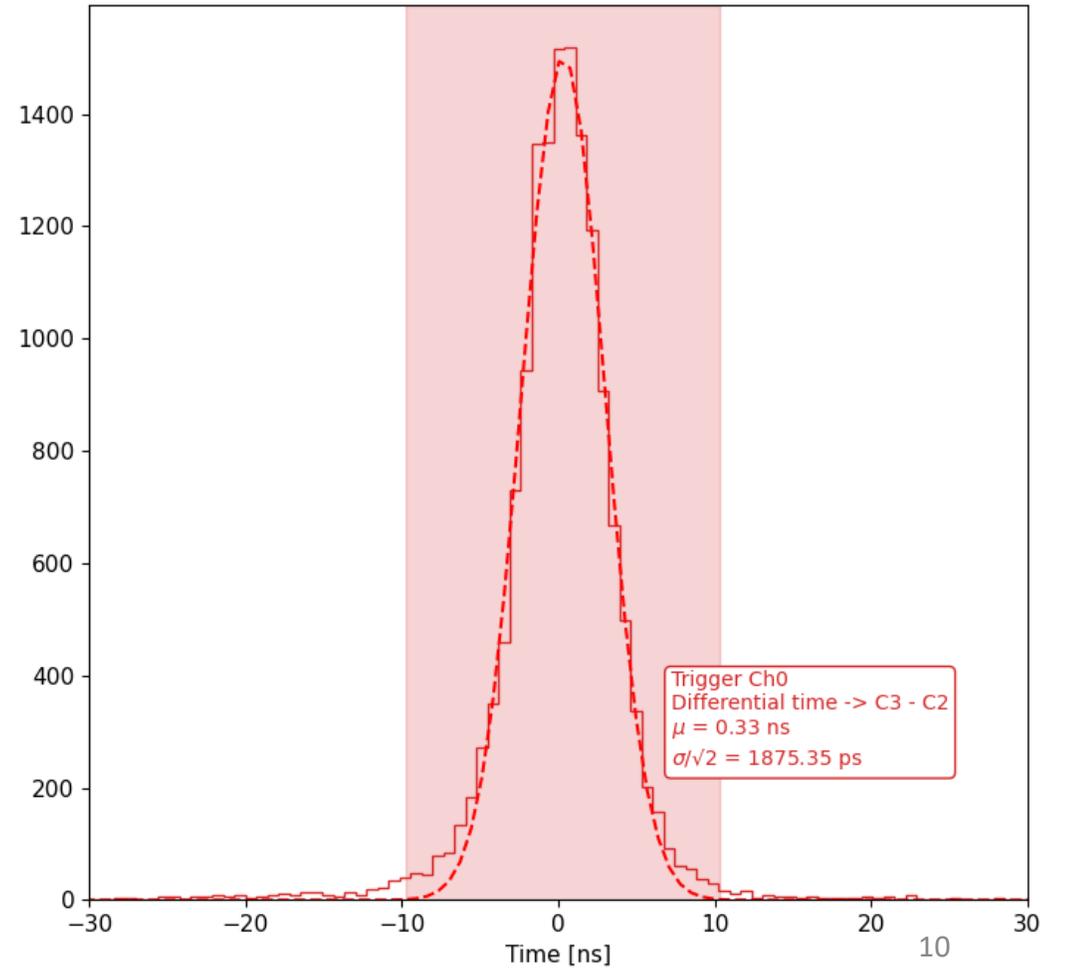
# Lab Tests: $^{90}\text{Sr}$ SetUp -> Advansid $3\times 3\text{ mm}^2$

-  $^{90}\text{Sr}$  Source SiPM AdvanSiD - 32.0 HV - Inflection position

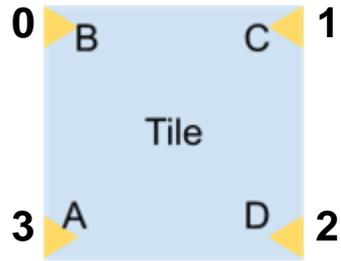


## Configuration 4

-  $^{90}\text{Sr}$  Source SiPM AdvanSiD - 32.0 HV - Inflection position



# Lab Tests: CR SetUp



## Configuration 5)

C0 -> 1 X SiPM AdvanSiD nuv 3x3 mm<sup>2</sup>

C1 -> 1 X SiPM AdvanSiD nuv 3x3 mm<sup>2</sup>

C2 -> 1 X SiPM AdvanSiD nuv 3x3 mm<sup>2</sup>

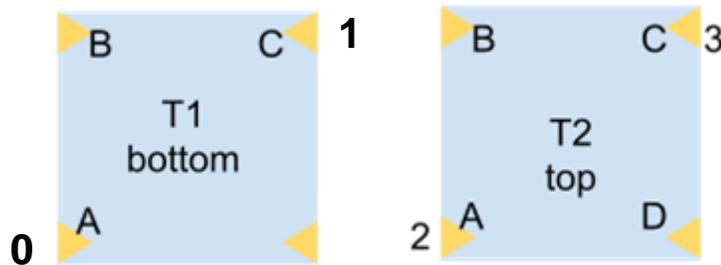
C3 -> 1 X SiPM AdvanSiD nuv 3x3 mm<sup>2</sup>

DAQ: Oscilloscope R&S 6GHz 20GS

Trigger: C1 AND C3 (NIM)

HV: 30.50 V (+2.5 OV)

## Configuration 6)



C0 -> 3 X SiPM 3x3 mm<sup>2</sup> Hamamatsu OR S14160-1315 (Long pcb)

C1 -> 3 X SiPM 3x3 mm<sup>2</sup> Hamamatsu OR S14160-1315 (Long pcb)

C2 -> 3 X SiPM 3x3 mm<sup>2</sup> Hamamatsu OR S14160-1315 (Long pcb)

C3 -> 3 X SiPM 3x3 mm<sup>2</sup> Hamamatsu OR S14160-1315 (Long pcb)

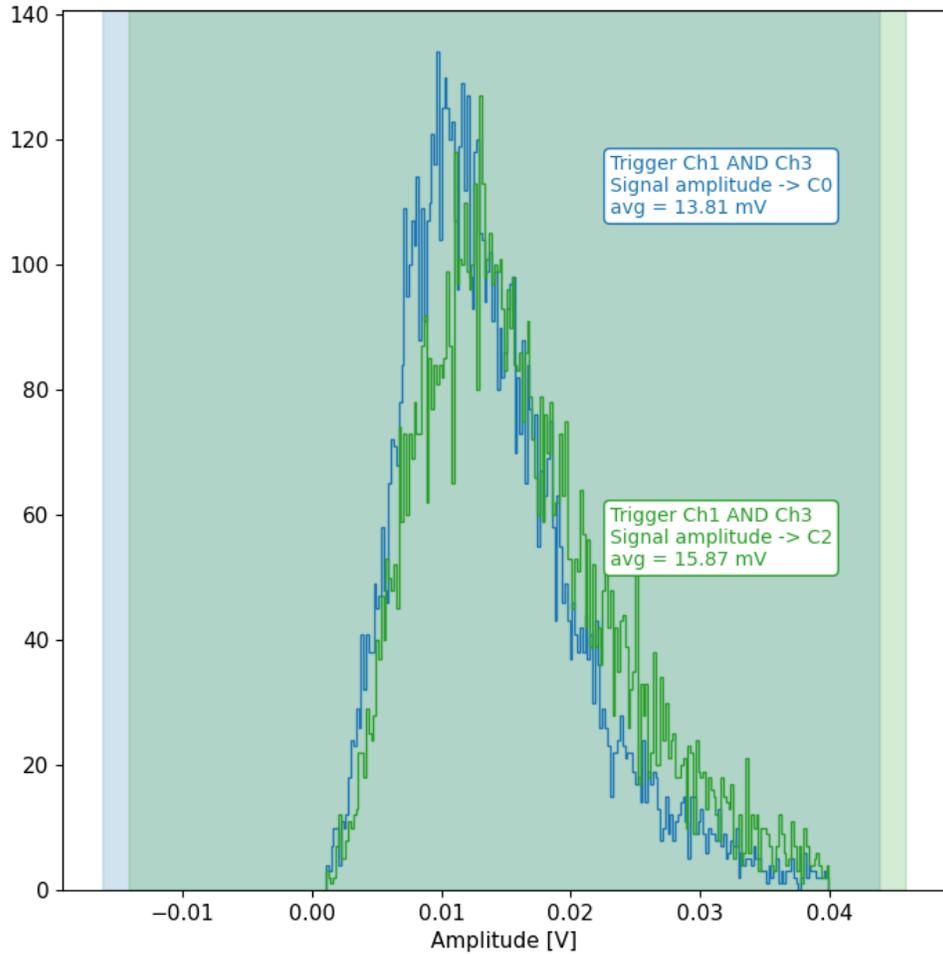
DAQ: Oscilloscope LeCroy 1GHz 20GS

Trigger: C0 AND C1 (Threshold 0.8 mV)

HV: 42.24 V (+4.24 OV)

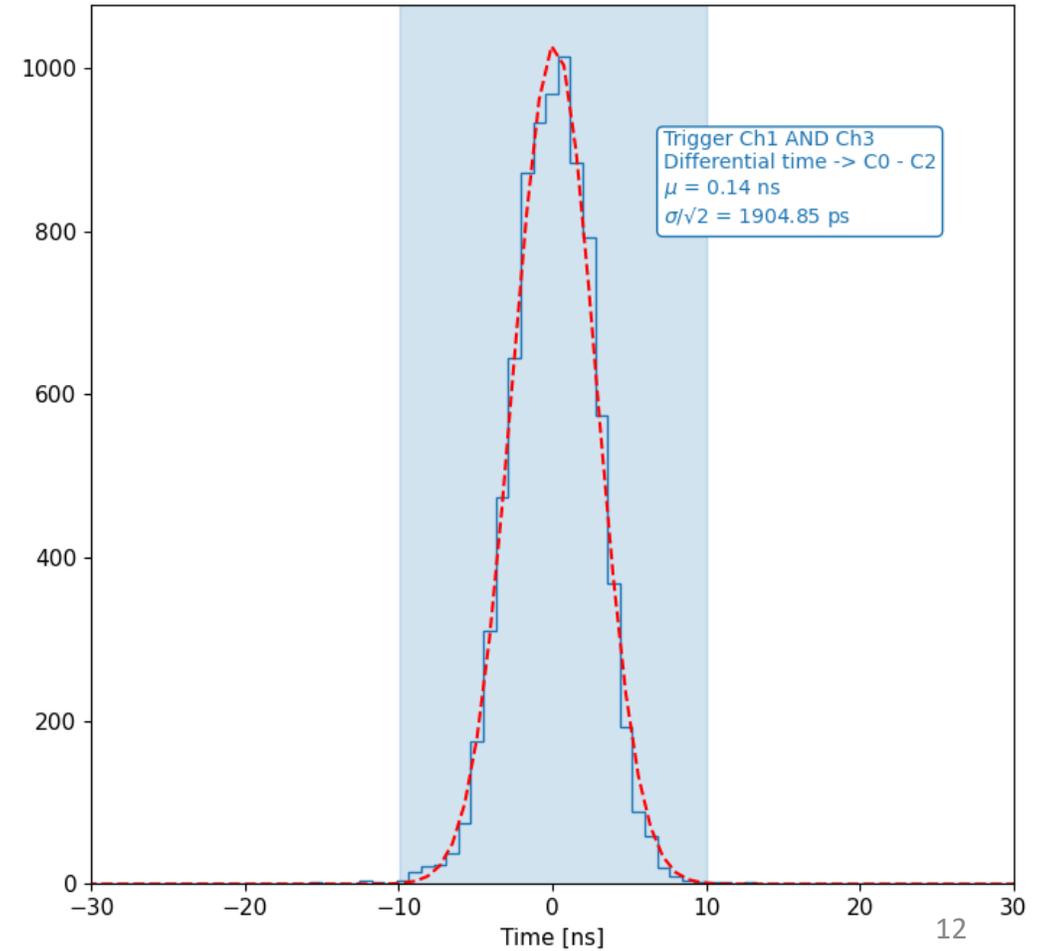
# Lab Tests: CR SetUp -> Advansid 3x3 mm<sup>2</sup>

- CR Source SiPM AdvanSiD - 30.5 HV - Amplitude distribution



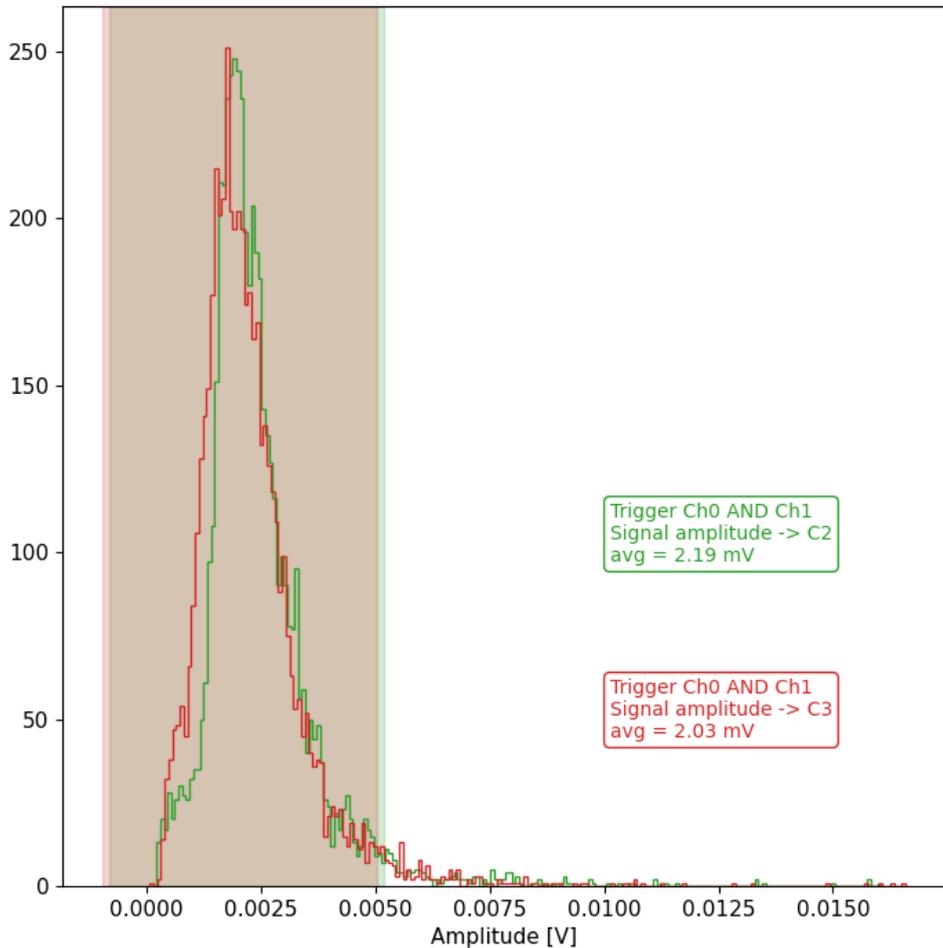
## Configuration 5

- CR Source SiPM AdvanSiD - 30.5 HV - Inflection position



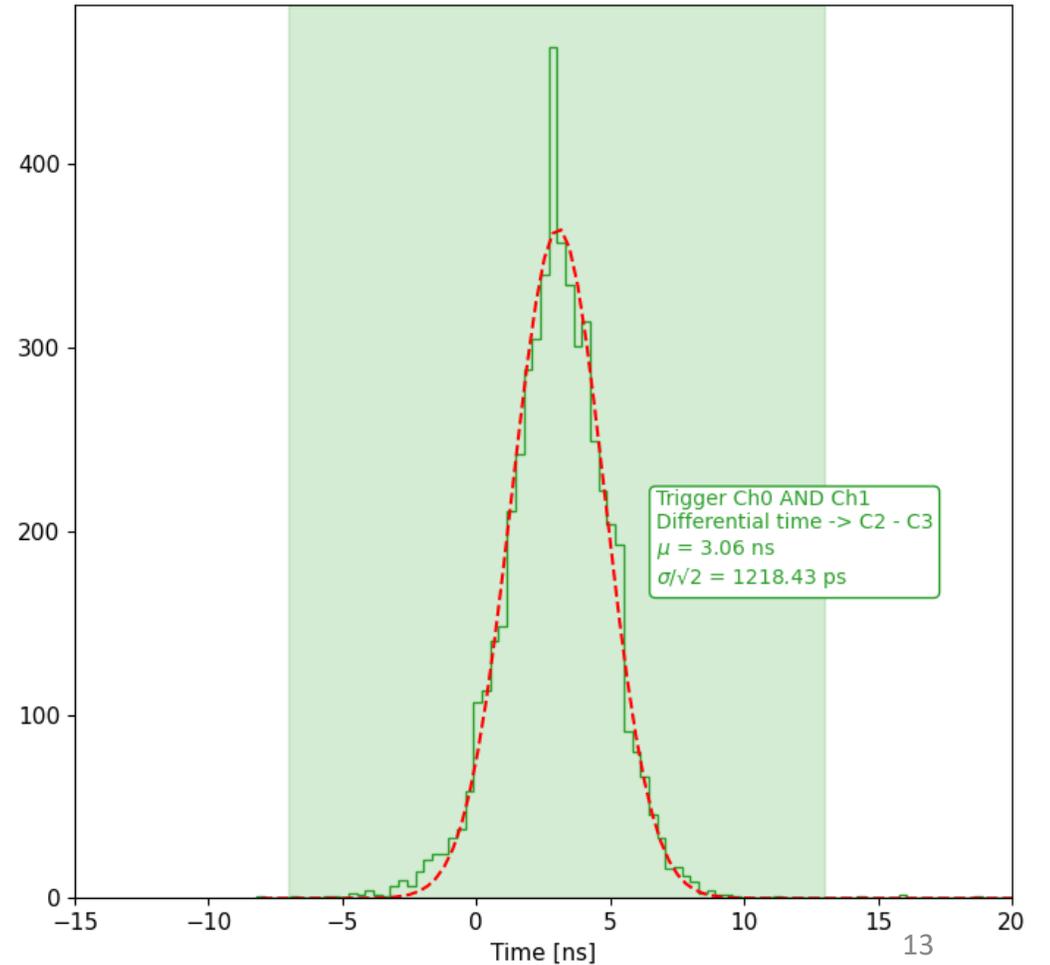
# Lab Tests: CR SetUp -> Hamamatsu 3x3 mm<sup>2</sup>

- CR Source SiPM Hamamatsu - 42.24 HV - Amplitude distribution



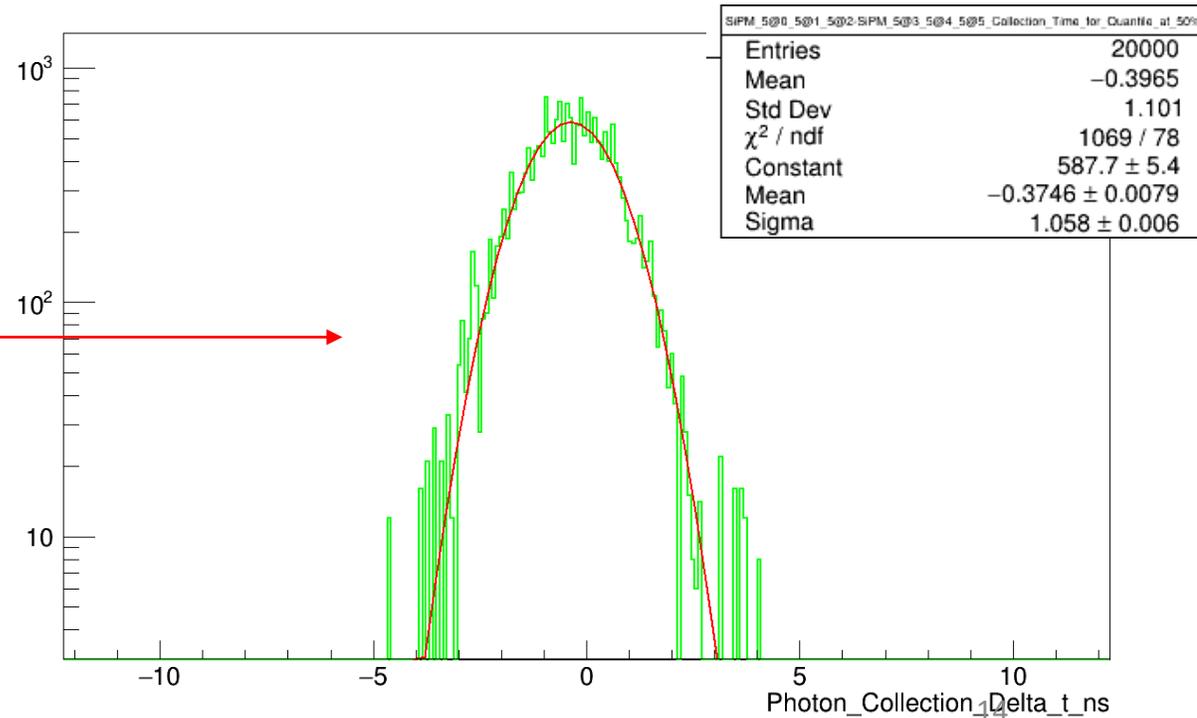
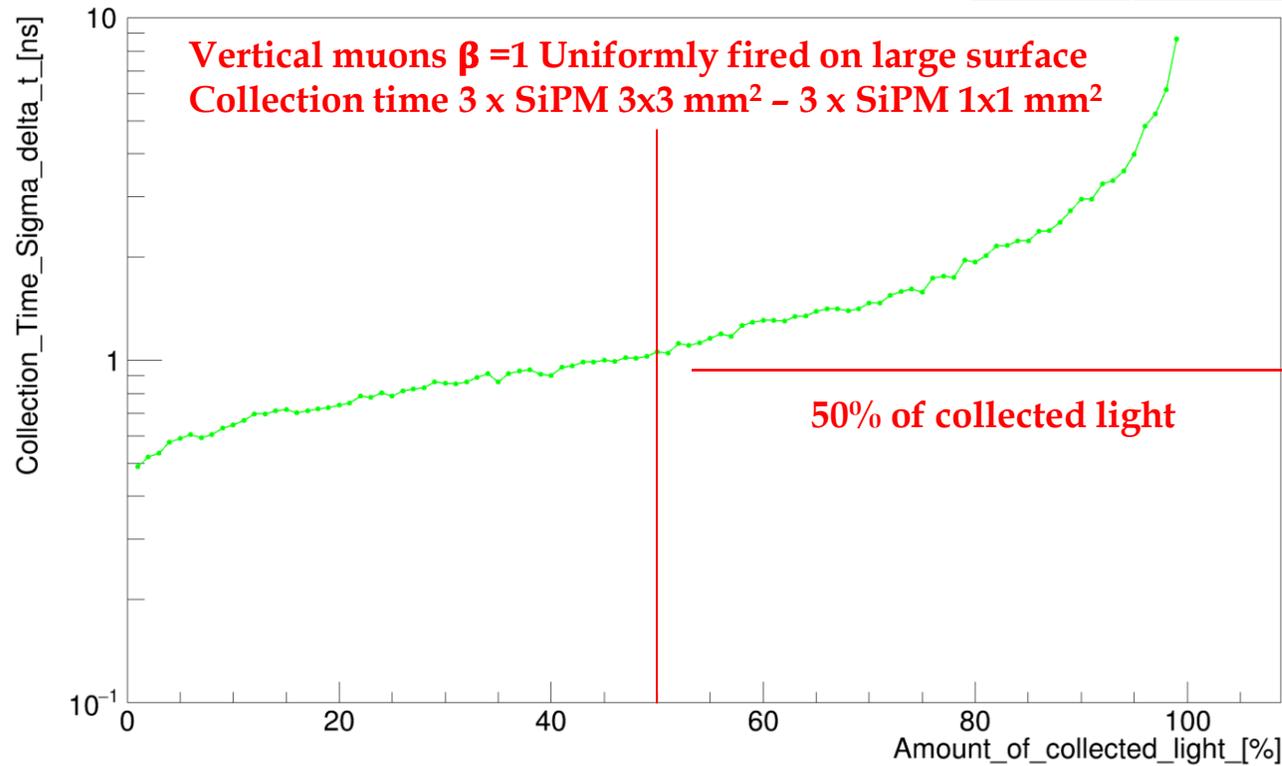
## Configuration 6

- CR Source SiPM Hamamatsu - 42.24 HV - Inflection position

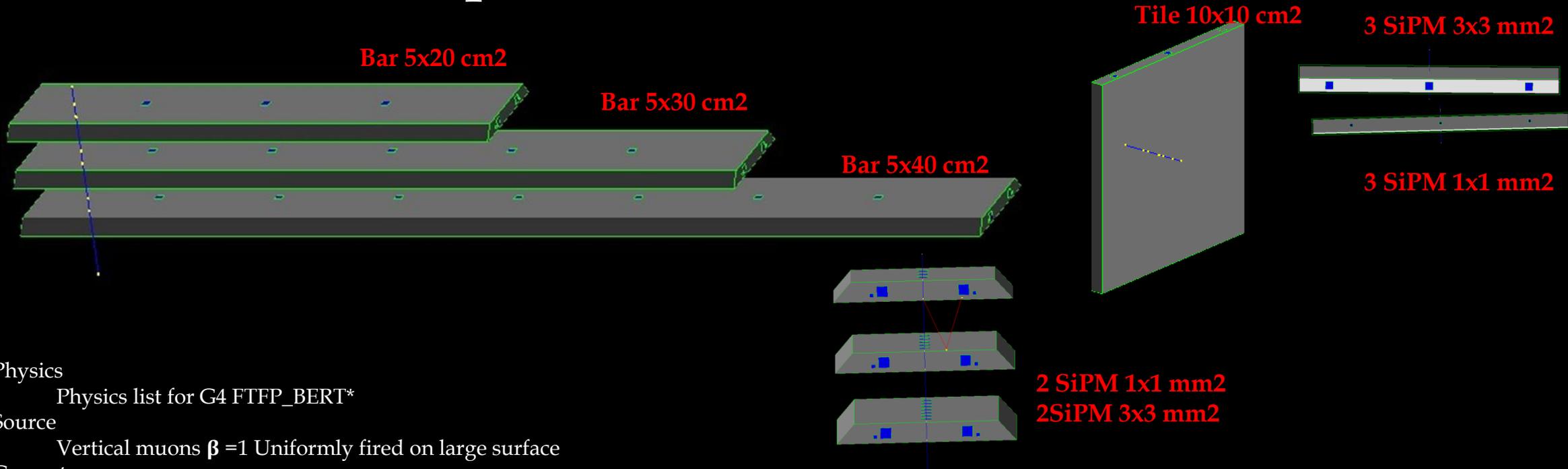


# Lab Tests: Results

Source	SiPM	Size	HV	$\sigma/\sqrt{2}$ [ps]
Laser	AdvanSiD	1 X 1x1 mm <sup>2</sup>	30.50	68
Laser	AdvanSiD	1 X 3x3 mm <sup>2</sup>	30.50	76
Laser	Hamamatsu	3 X 1x1 mm <sup>2</sup> Vs 3 X 3x3 mm <sup>2</sup>	42.00	60
90Sr	AdvanSiD	1 X 3x3 mm <sup>2</sup>	32.00	1870
CR	AdvanSiD	1 X 3x3 mm <sup>2</sup>	30.50	1941
CR	Hamamatsu	3 X 3x3 mm <sup>2</sup>	42.24	1235
Mu+	Simulation	3 X 1x1 mm <sup>2</sup> Vs 3 X 3x3 mm <sup>2</sup>		748



# Simulation SetUp



## Physics

Physics list for G4 FTFP\_BERT\*

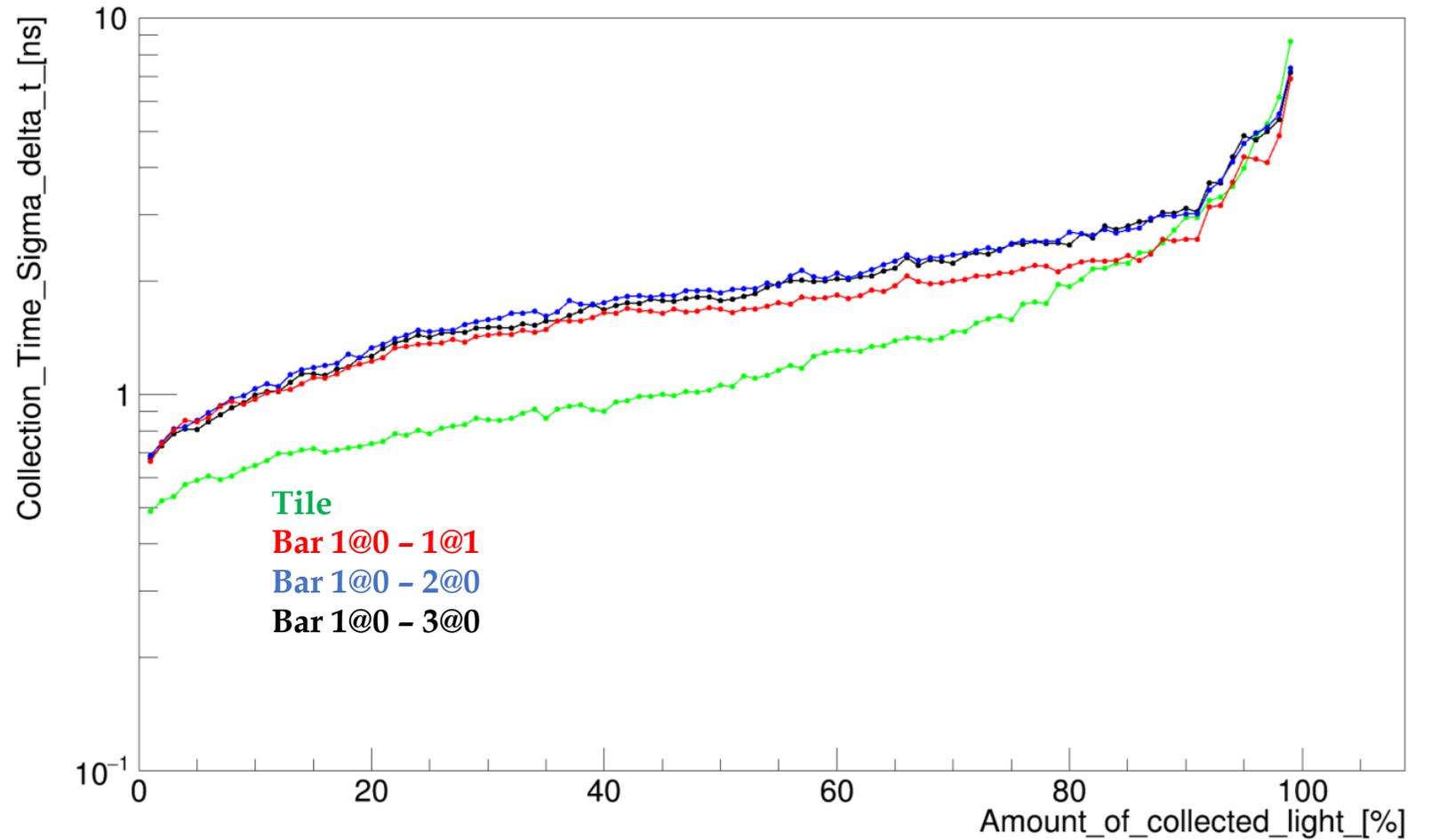
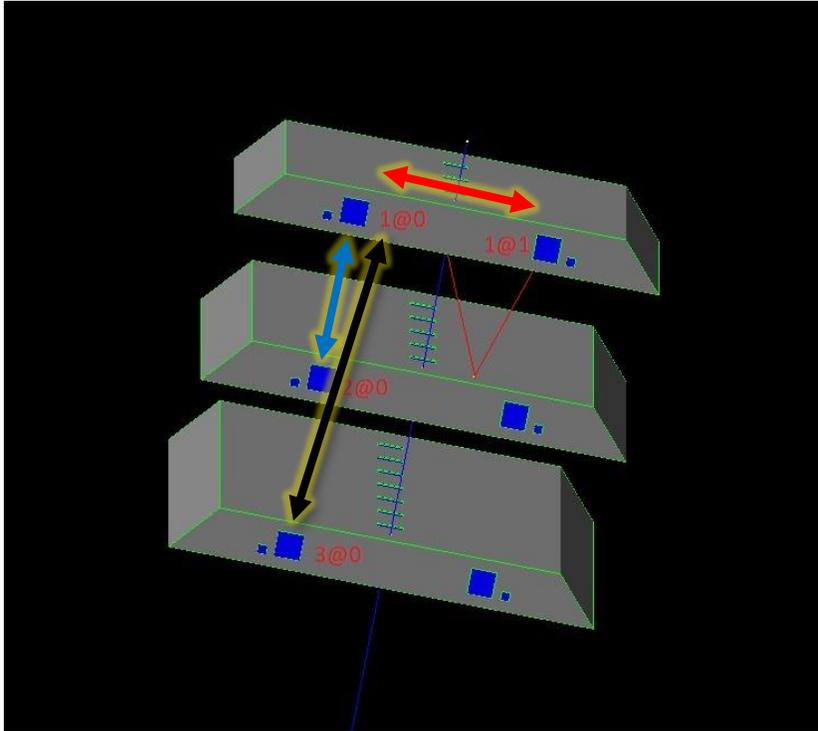
## Source

Vertical muons  $\beta = 1$  Uniformly fired on large surface

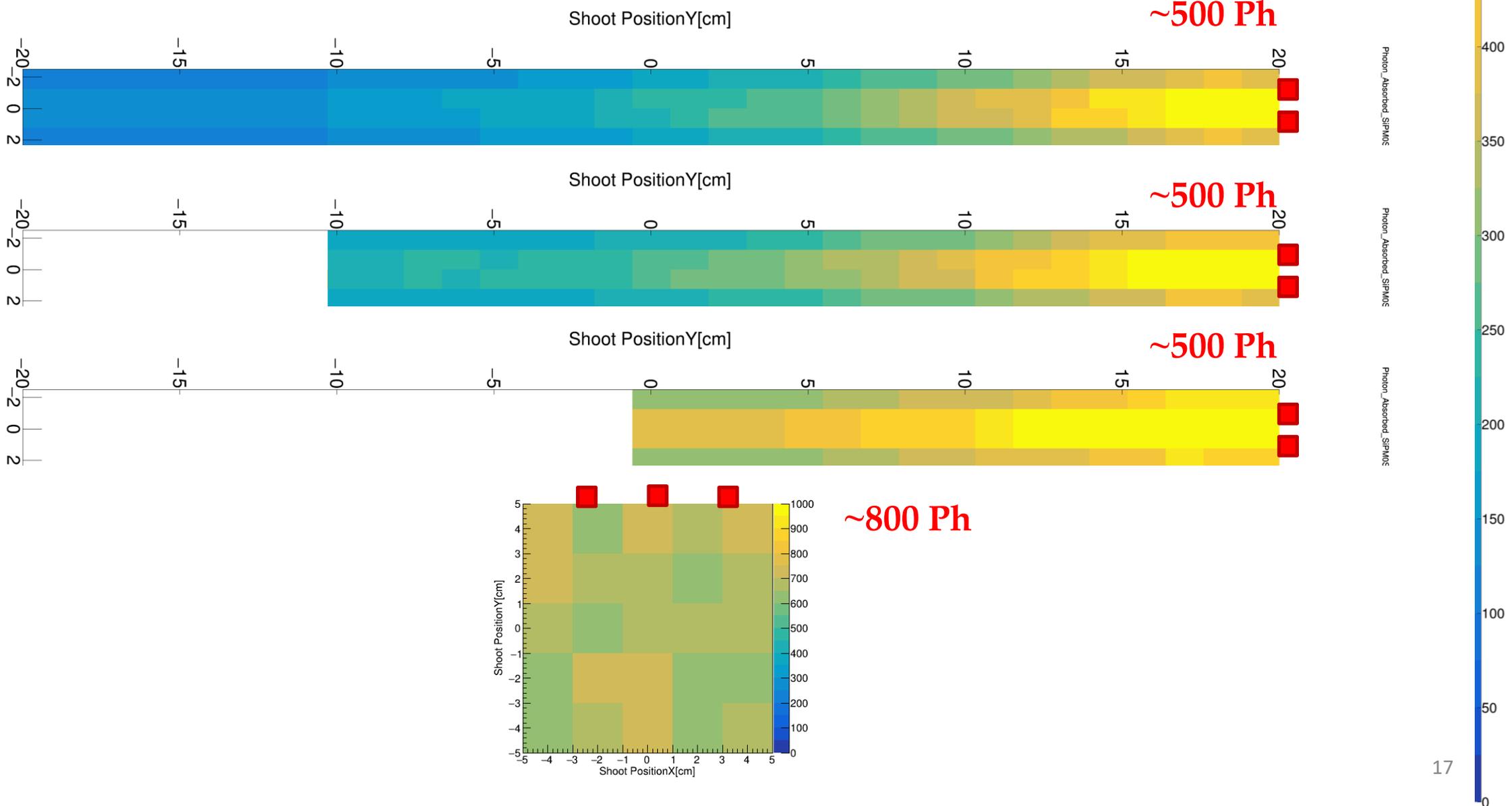
## Geometry

- 1) Tile 10x10x0.5 cm<sup>3</sup> -> 3 SiPM 3x3 mm<sup>2</sup> on Top + 3 SiPM 1x1 mm<sup>2</sup> on Bottom
- 2) Bar A 5x20x0.5 cm<sup>3</sup> -> 4 SiPM on large side + 8 SiPM (4 3x3 and 4 1x1) on small sides (4SiPM for each side)
- 3) Bar B 5x30x0.5 cm<sup>3</sup> -> 6 SiPM on large side + 8 SiPM (4 3x3 and 4 1x1) on small sides (4SiPM for each side)
- 4) Bar C 5x40x0.5 cm<sup>3</sup> -> 8 SiPM on large side + 8 SiPM (4 3x3 and 4 1x1) on small sides (4SiPM for each side)

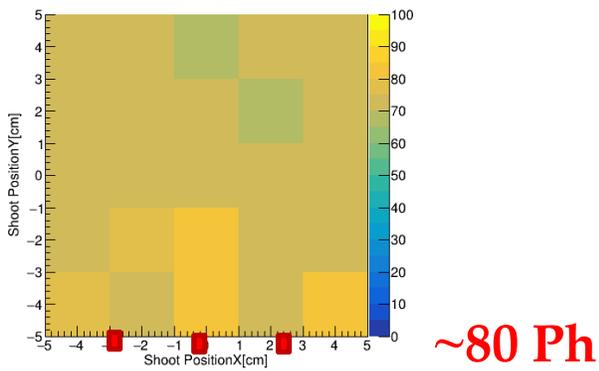
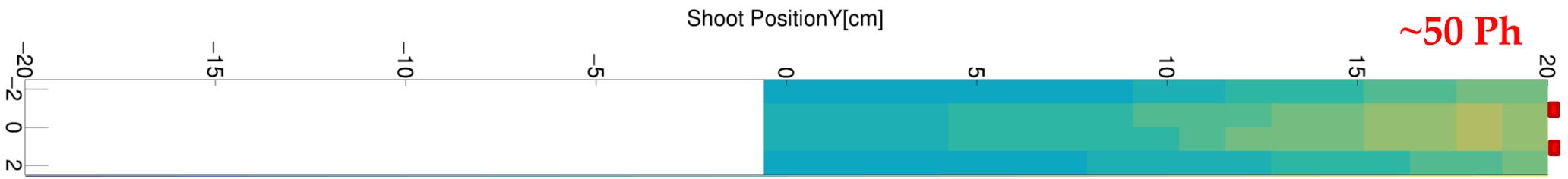
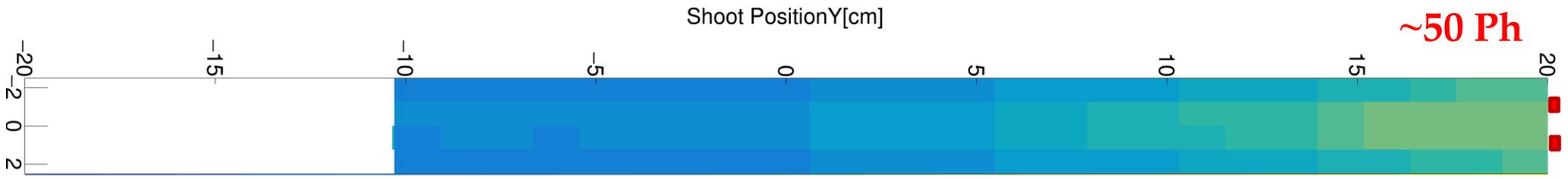
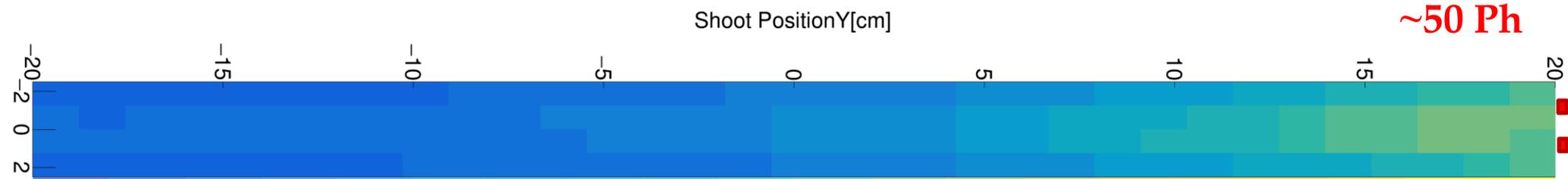
# Simulation timing results



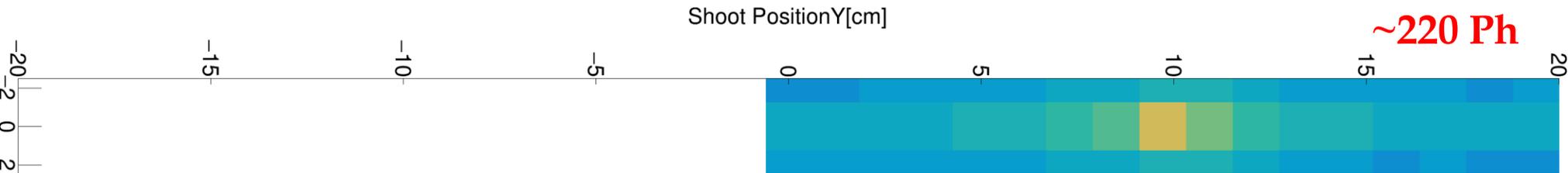
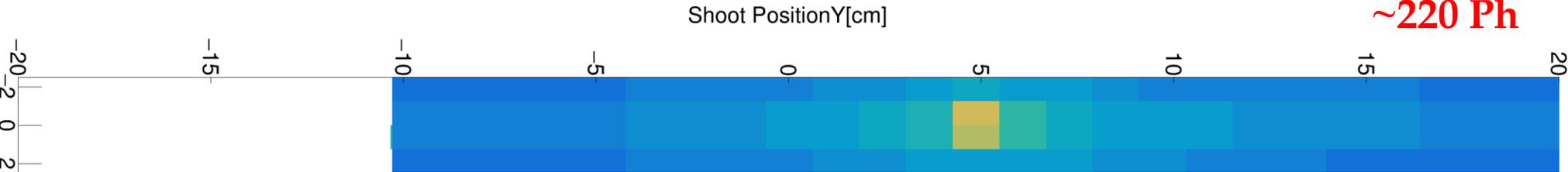
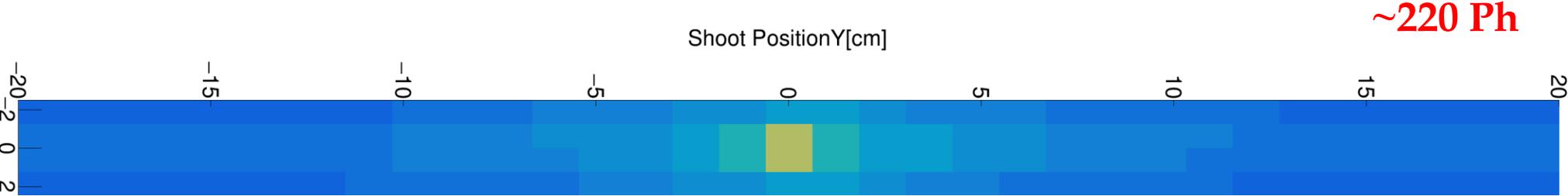
# Photon collected: Large SiPM



# Photon collected: Small SiPM

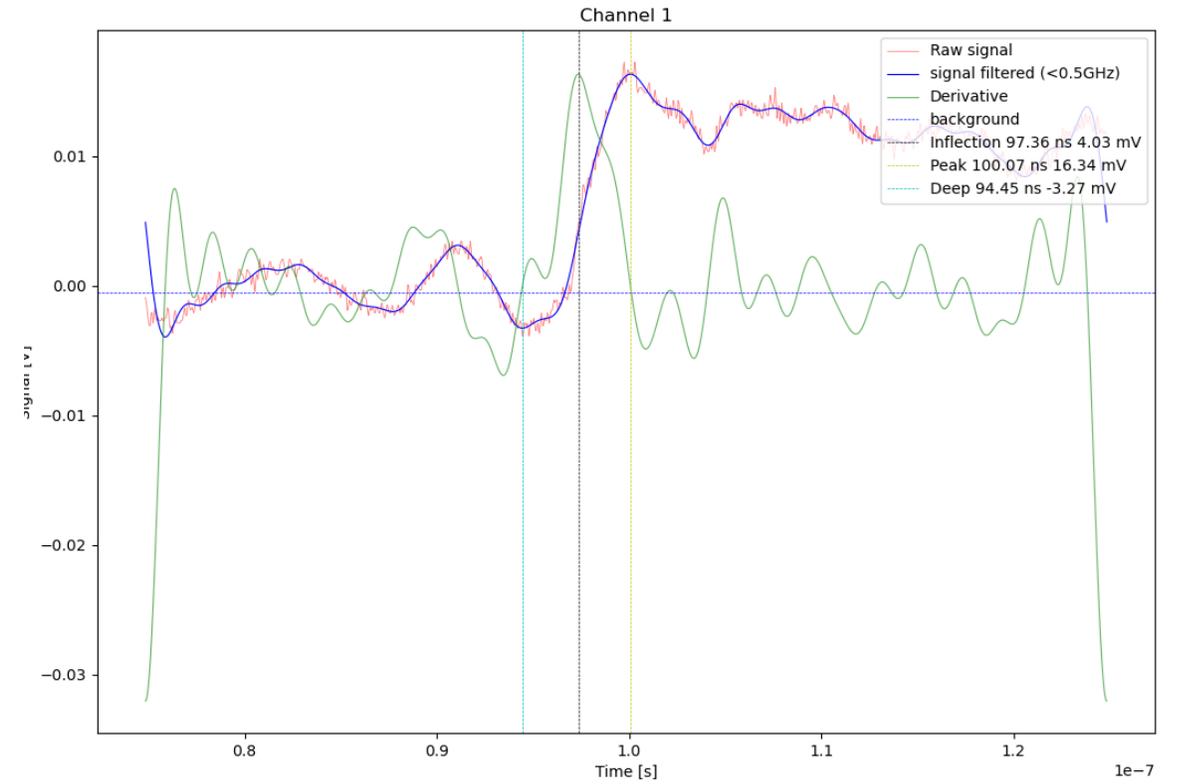
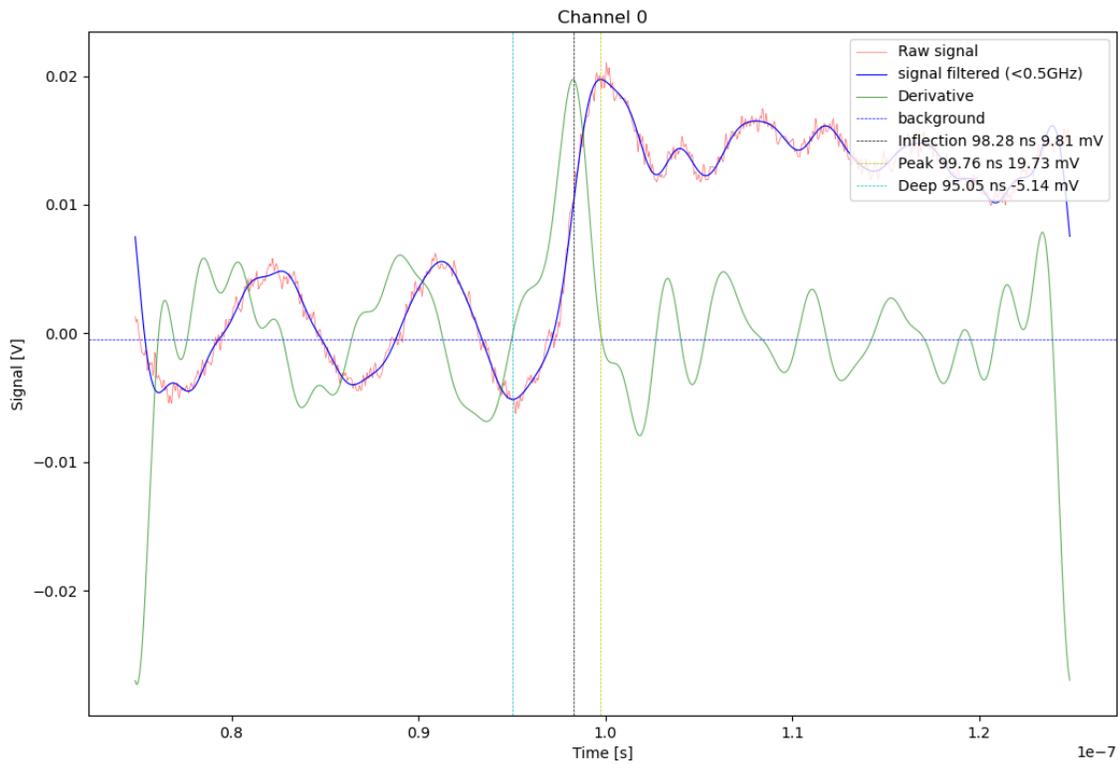


# Photon collected: Top SiPM

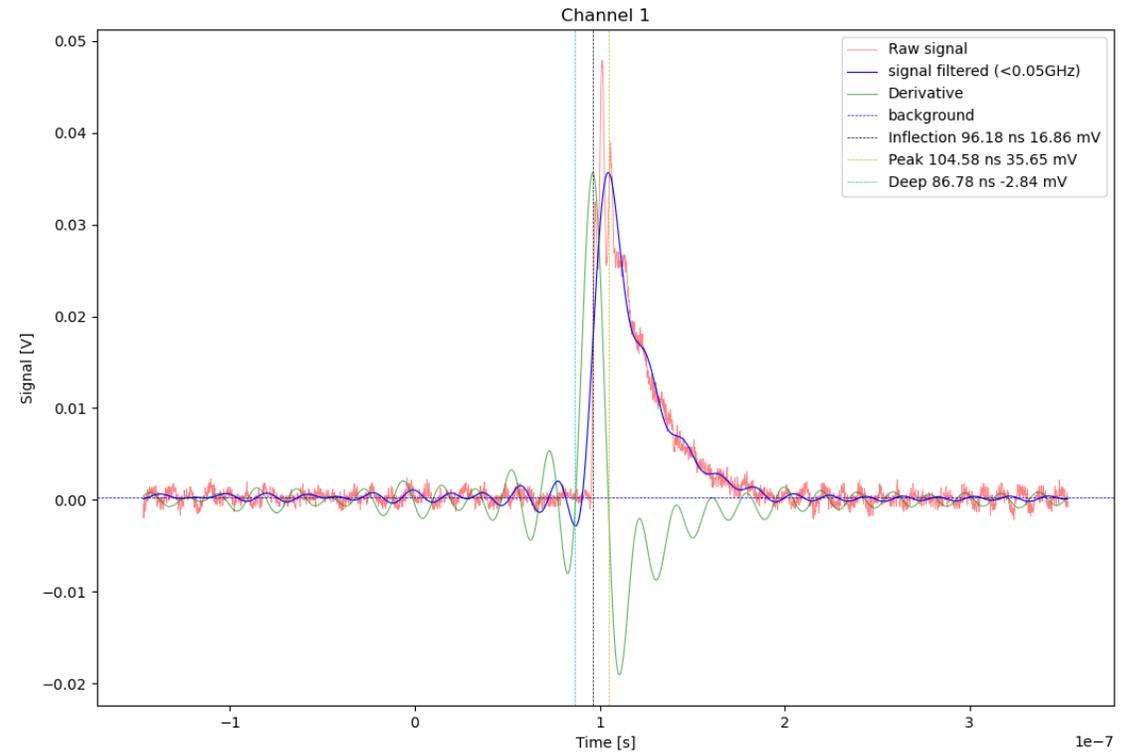
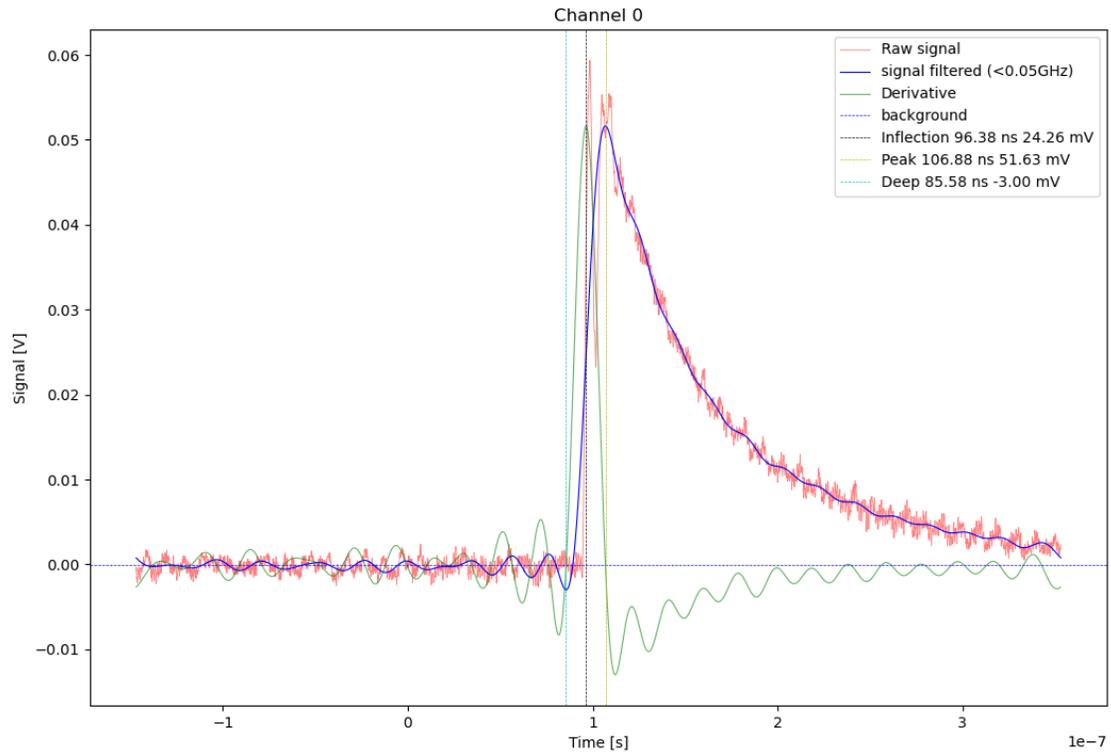


# BackUp Slides

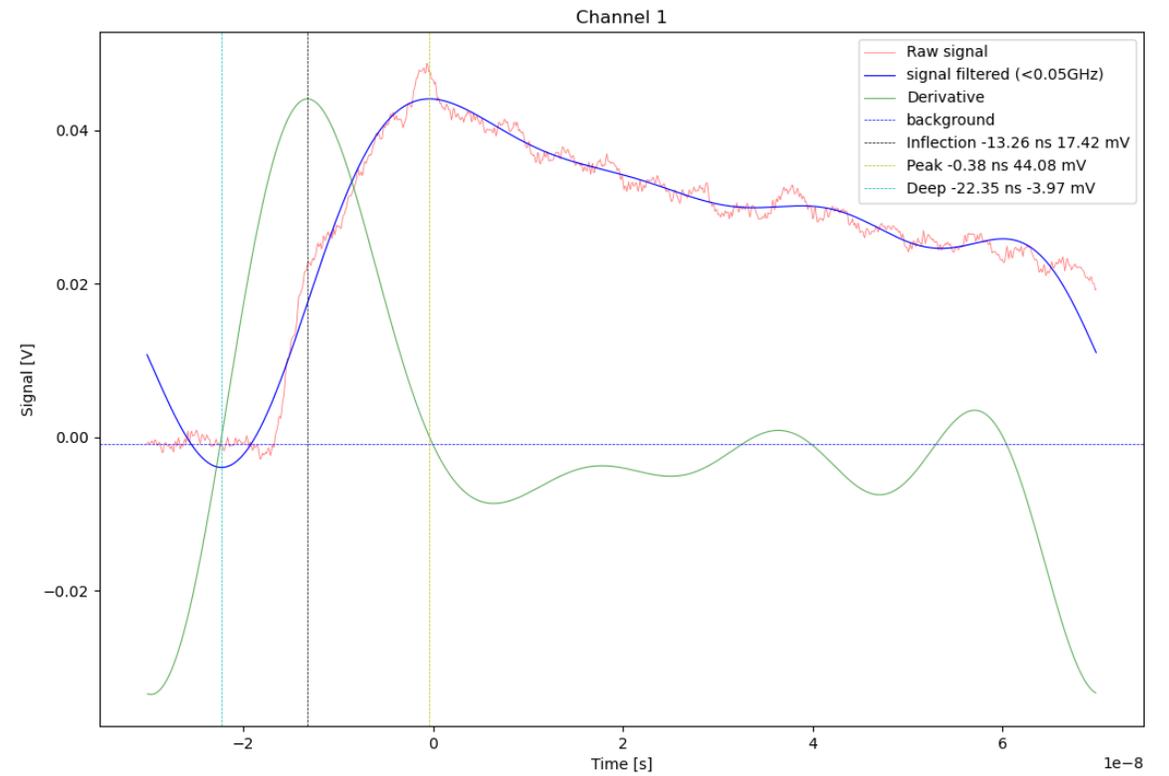
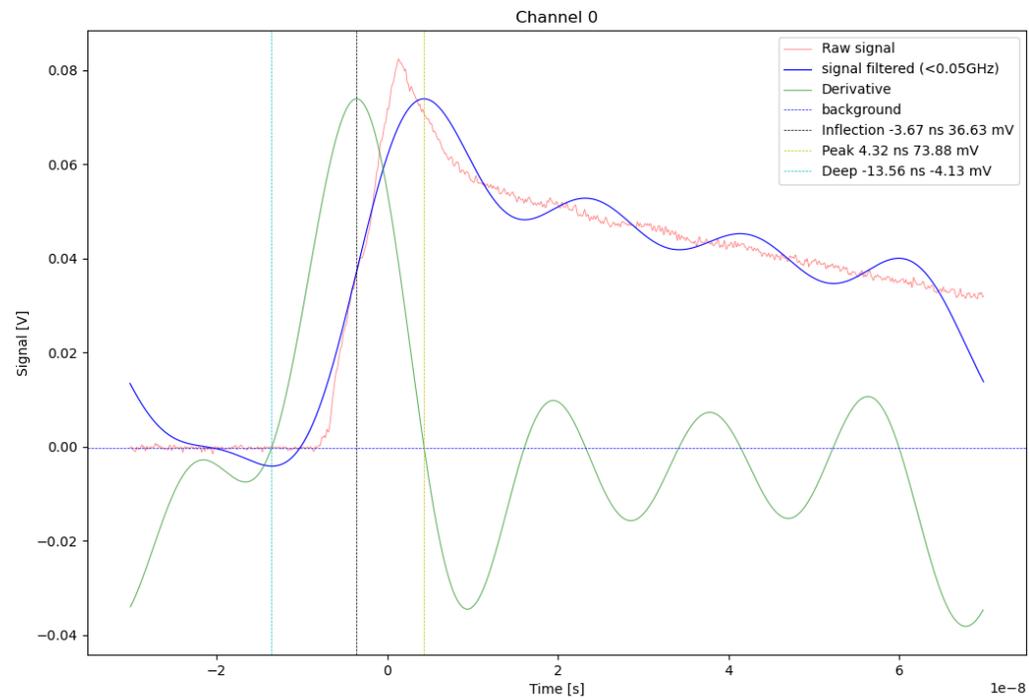
# Waveform: Laser SiPM AdvanSiD



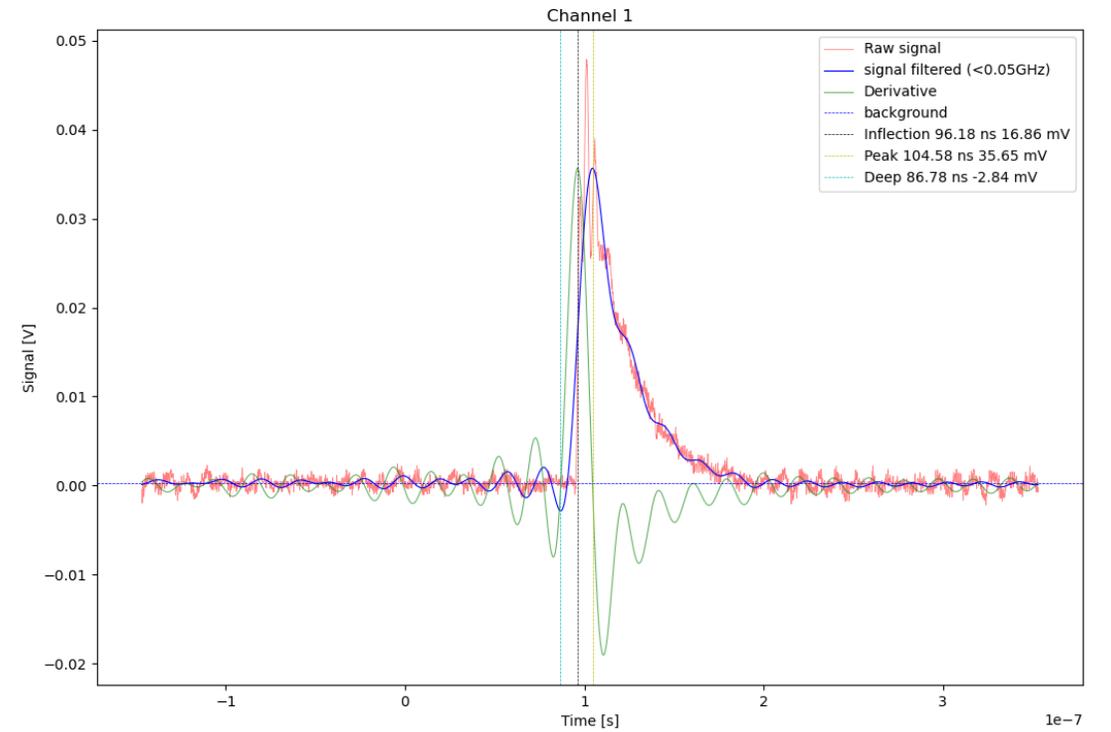
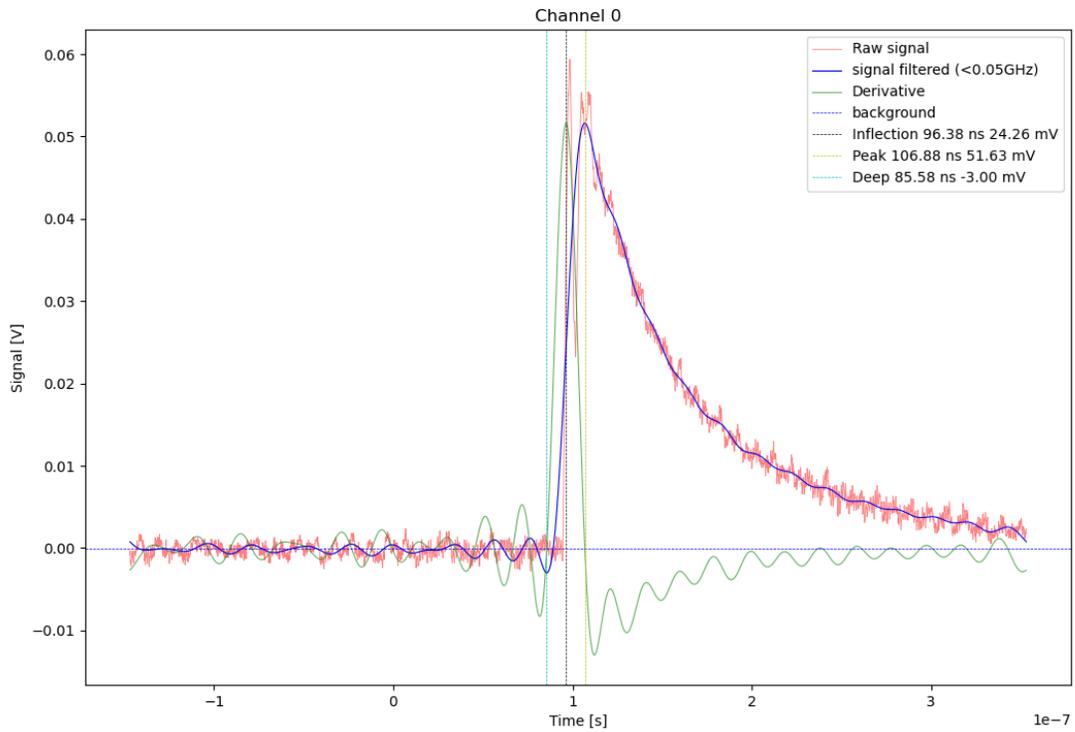
# Waveform: Laser Hamamatsu



# Waveform: <sup>90</sup>Sr SiPM AdvanSiD

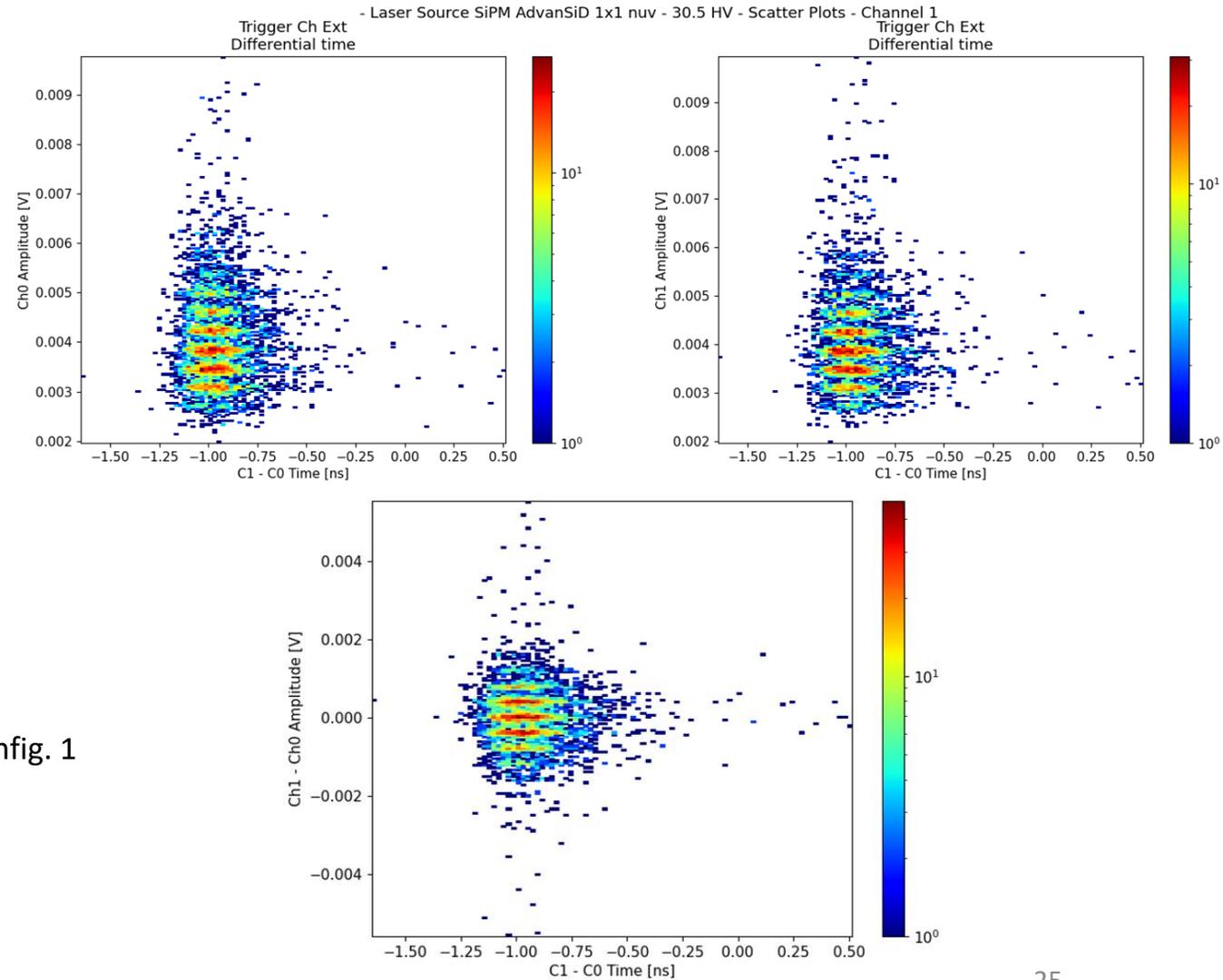
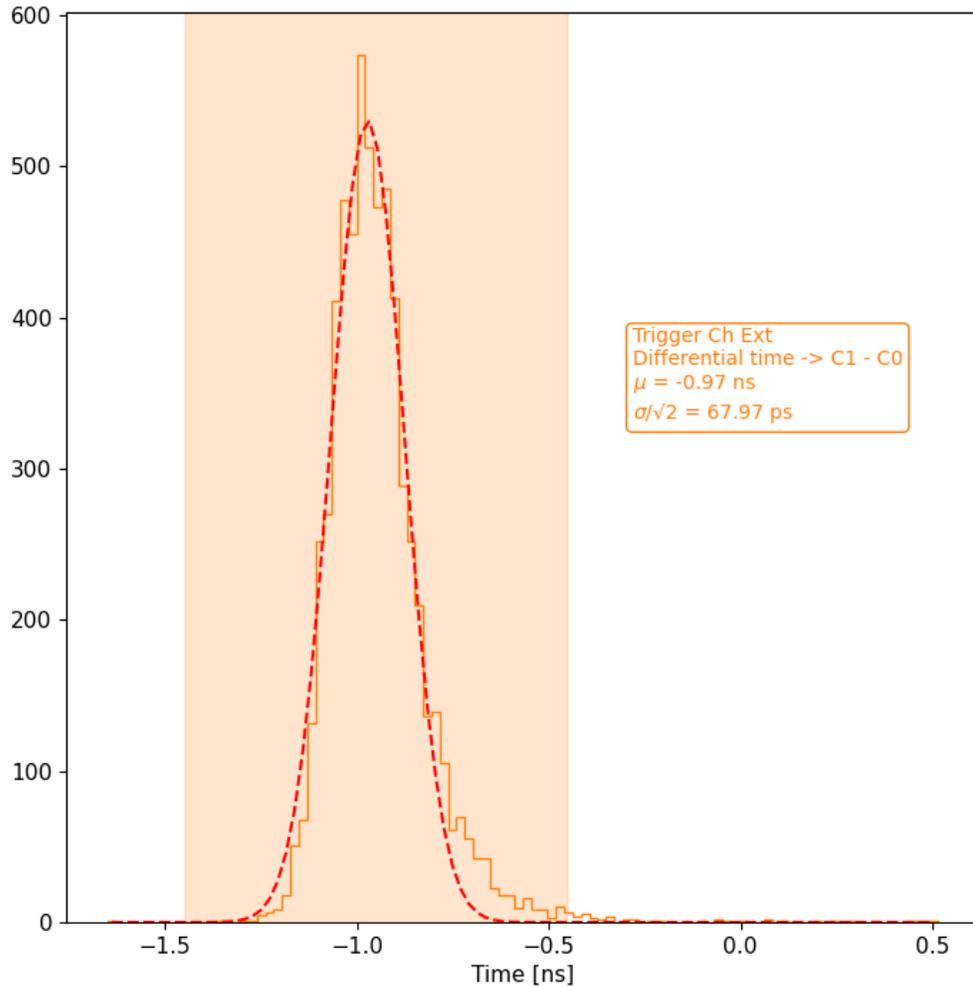


# Waveform: CR SiPM Hamamtsu



# Lab Tests: Laser SetUp -> Advansid 1x1 mm<sup>2</sup>

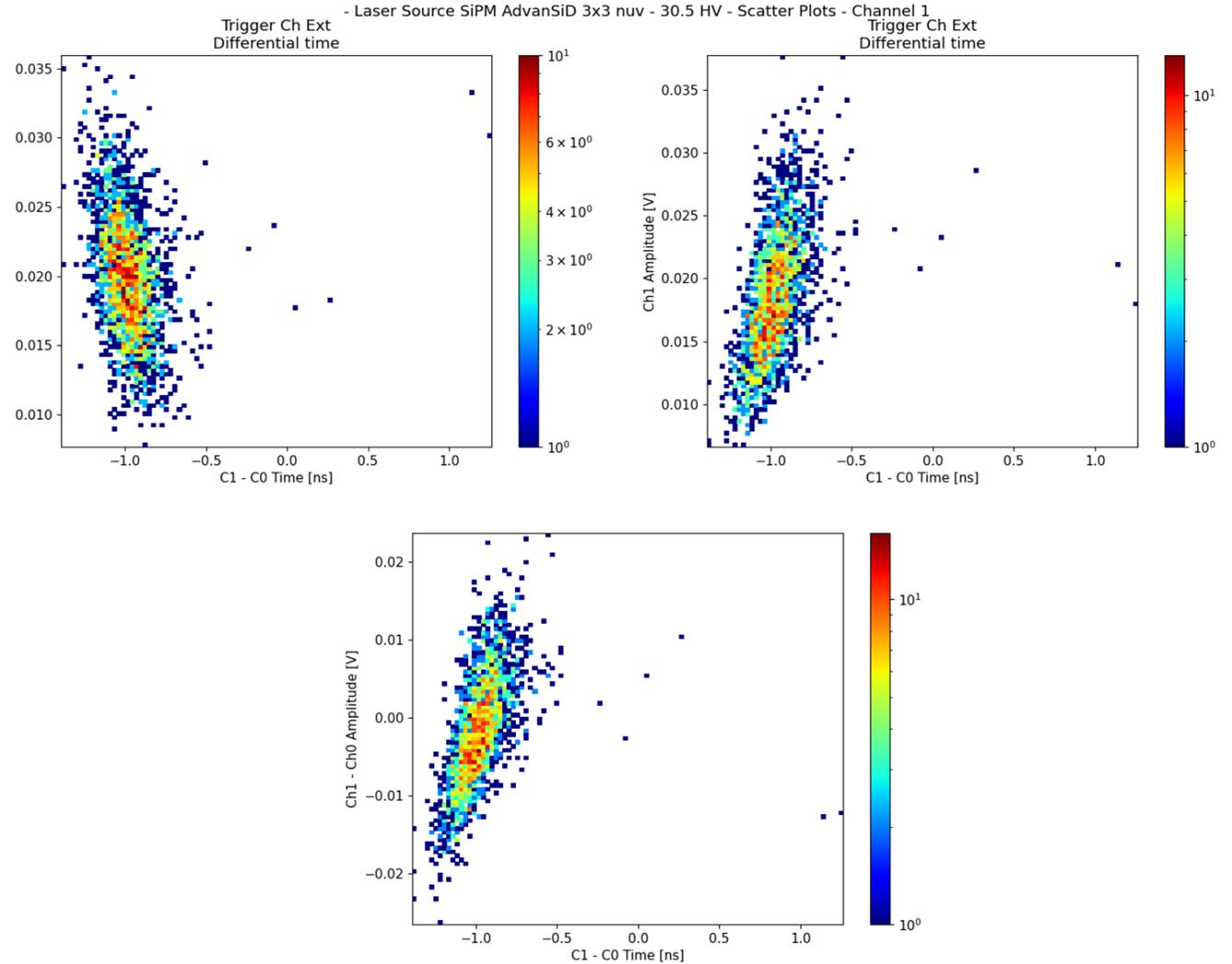
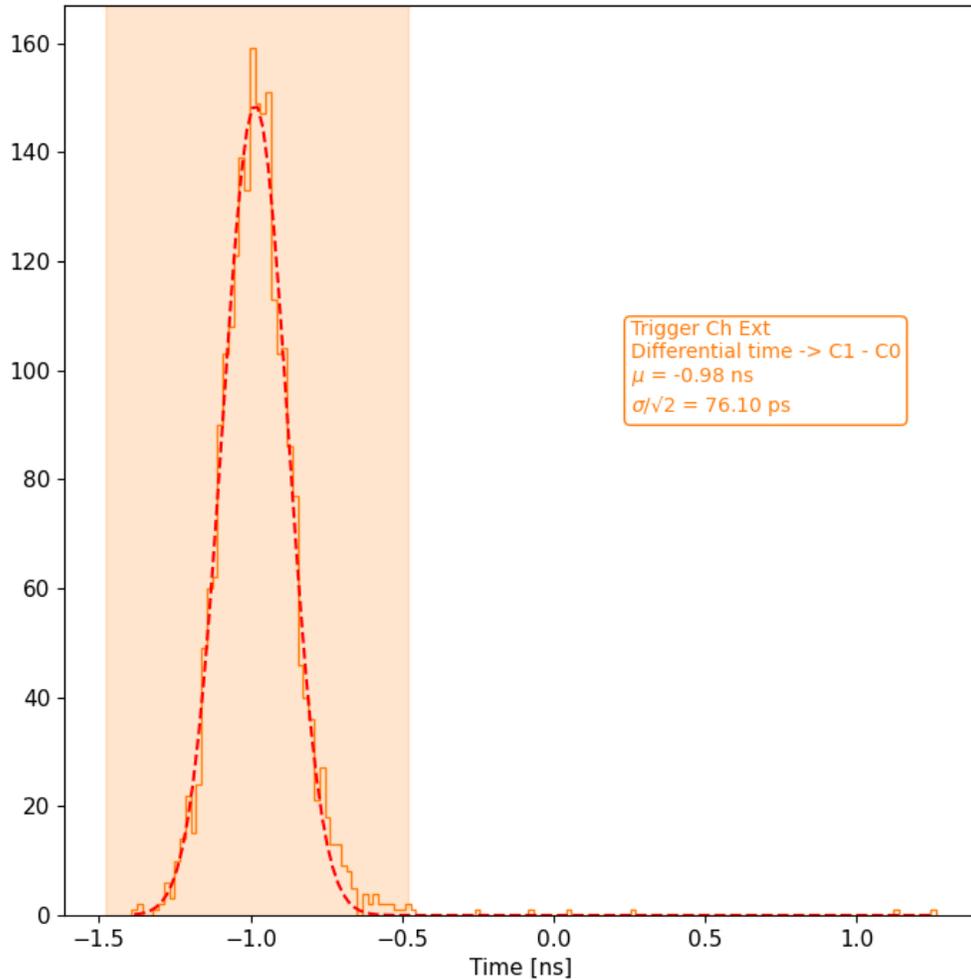
- Laser Source SiPM AdvanSiD 1x1 nuv - 30.5 HV - Inflection position



Config. 1

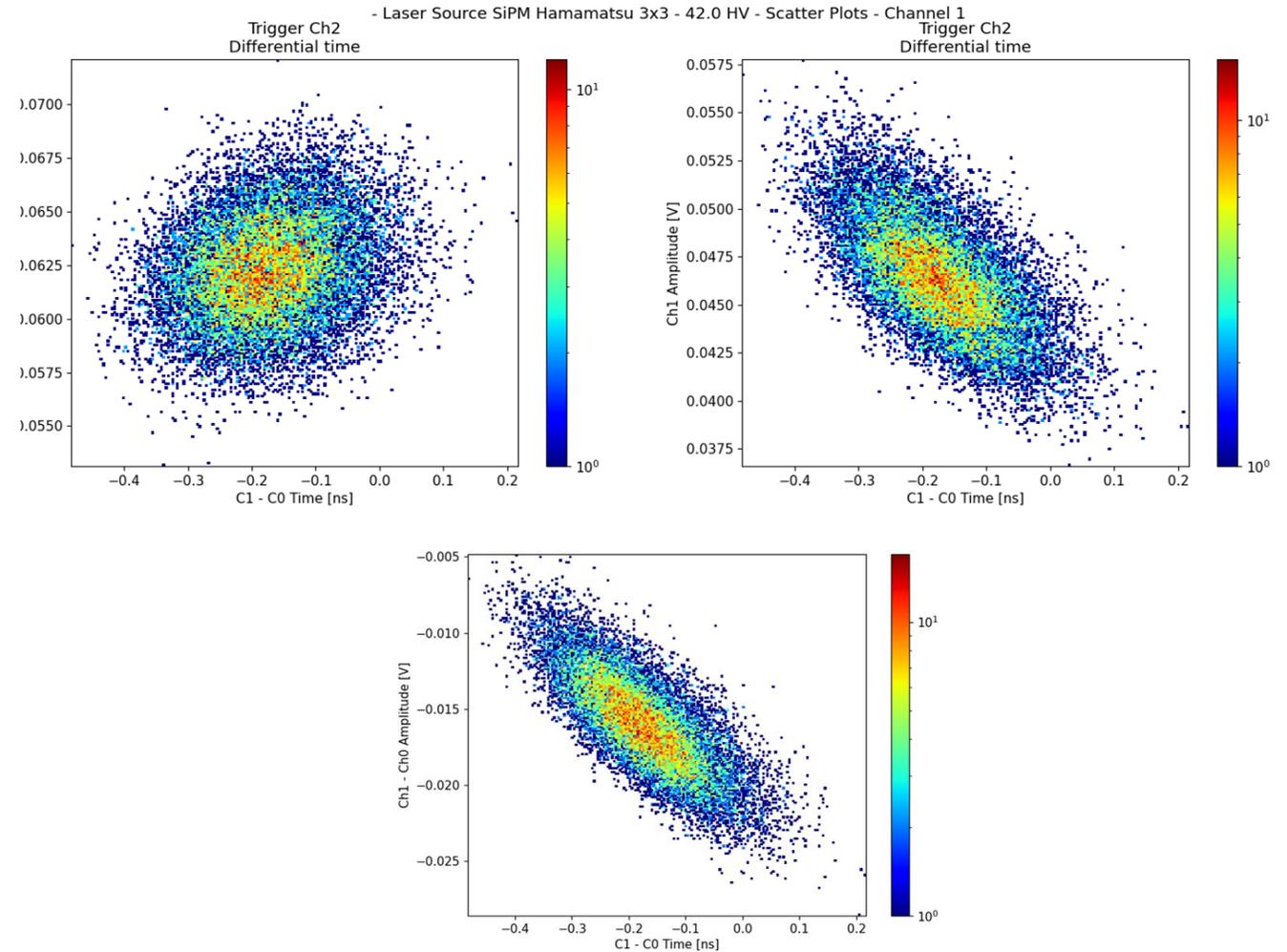
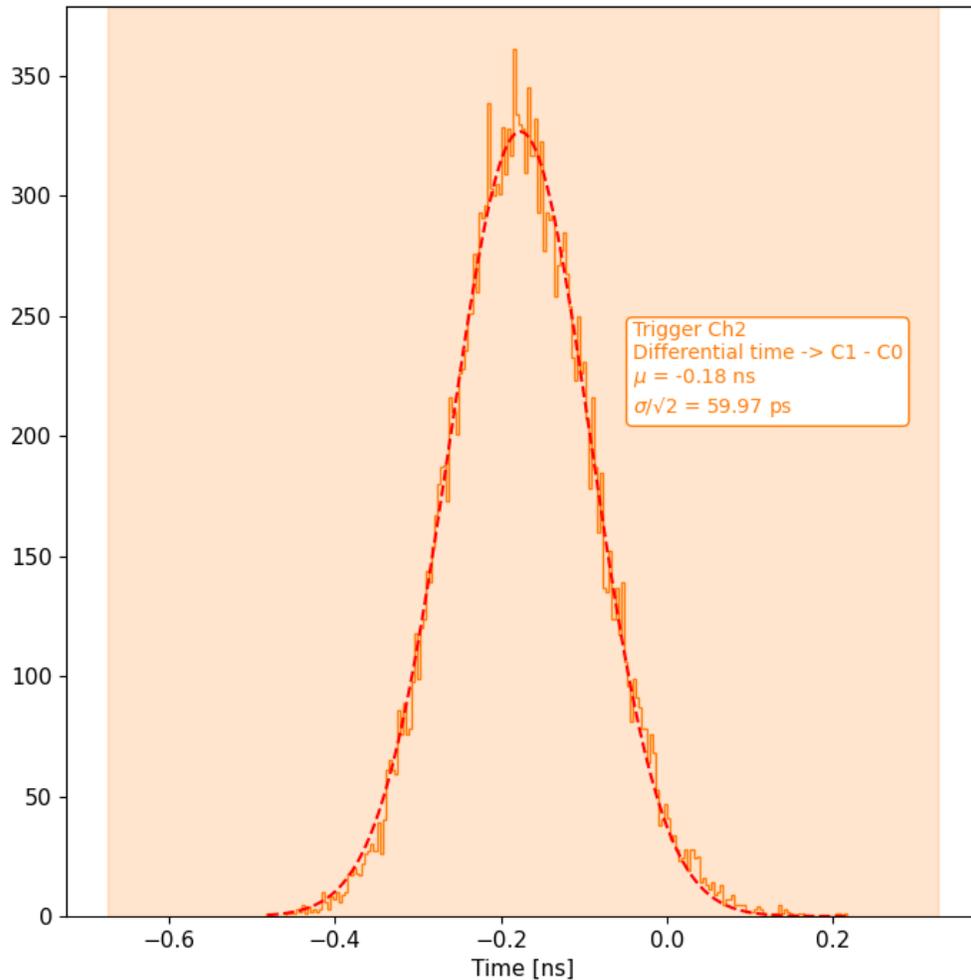
# Lab Tests: Laser SetUp -> Advansid 3x3 mm<sup>2</sup>

- Laser Source SiPM AdvanSiD 3x3 nuv - 30.5 HV - Inflection position



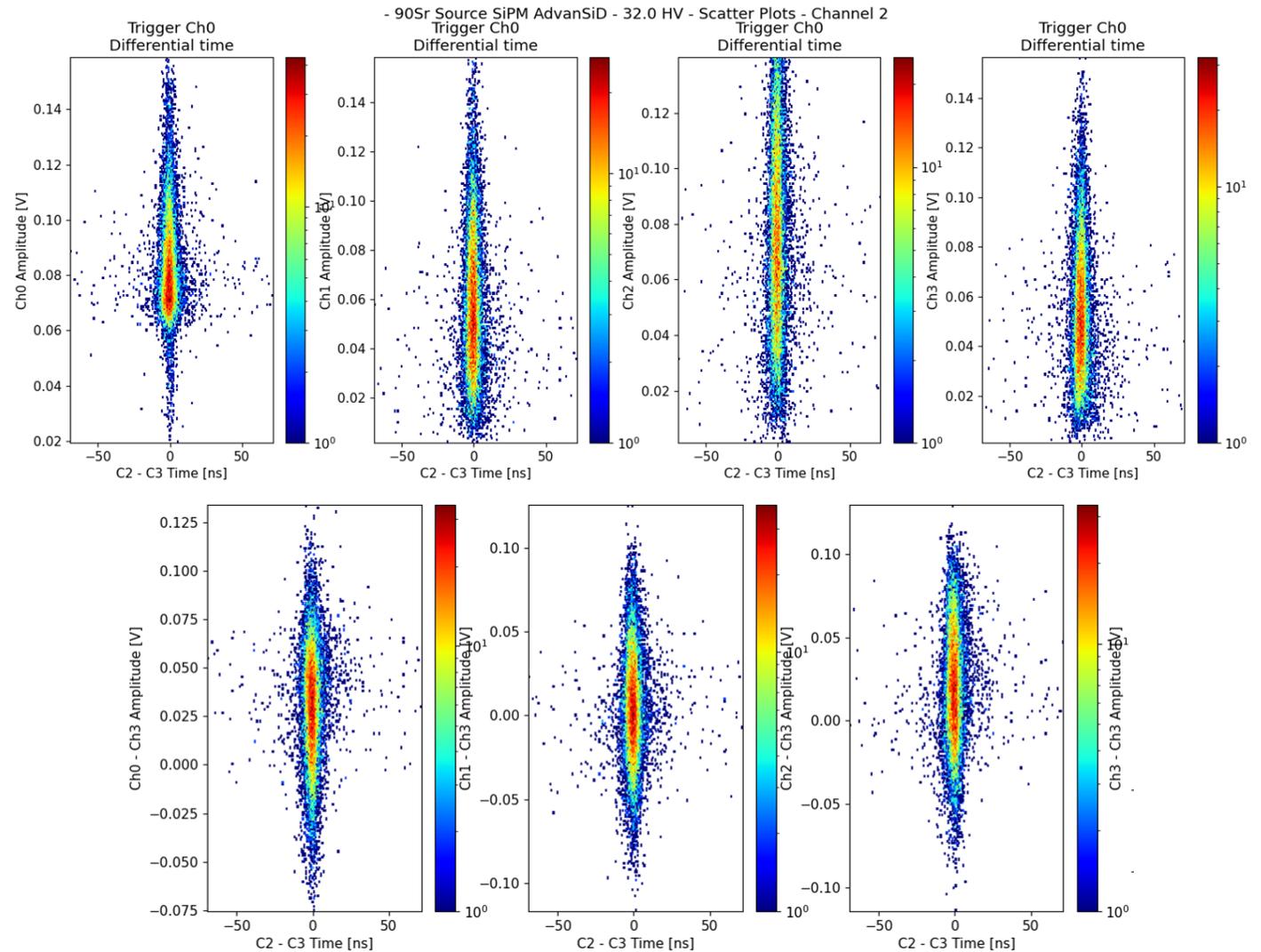
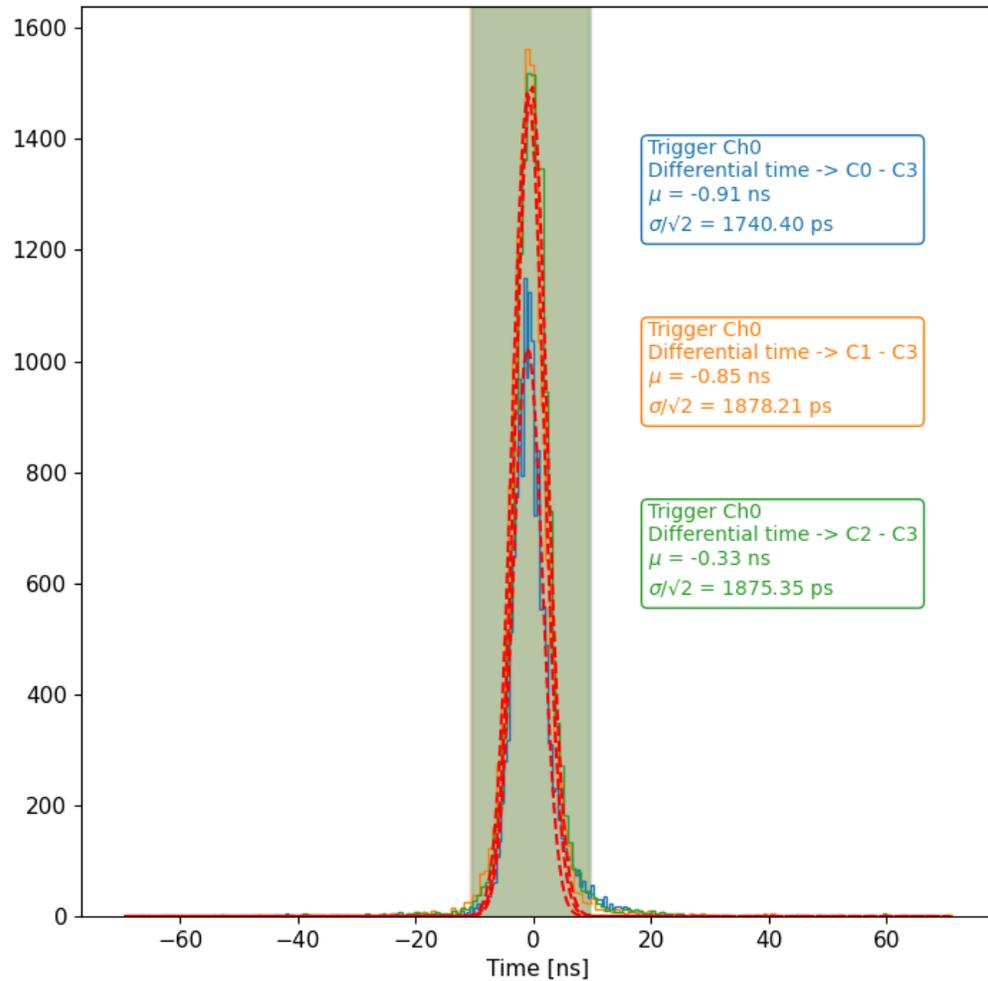
# Lab Tests: Laser SetUp -> Hamamatsu pcb 1x1 mm<sup>2</sup> and 3x3 mm<sup>2</sup>

- Laser Source SiPM Hamamatsu 3x3 - 42.0 HV - Inflection position



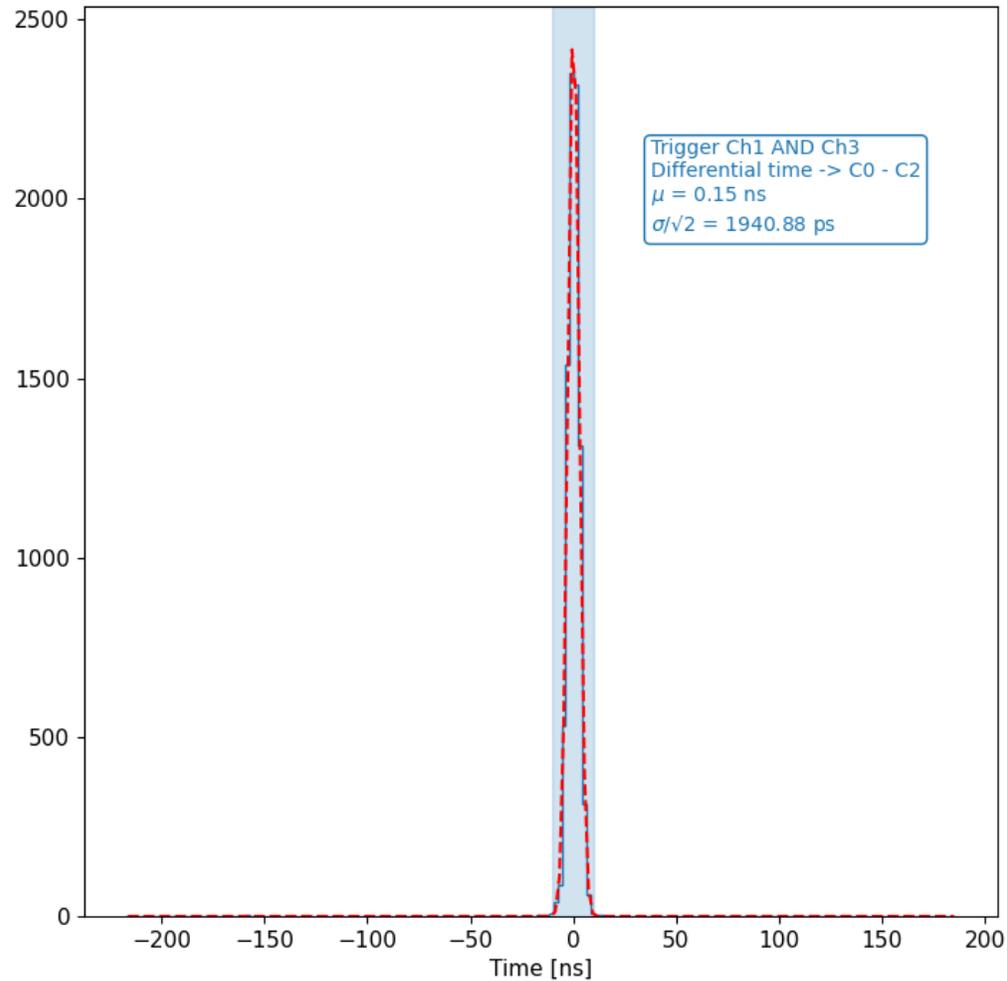
# Lab Tests: $^{90}\text{Sr}$ SetUp $\rightarrow$ Advansid $3 \times 3 \text{ mm}^2$

-  $^{90}\text{Sr}$  Source SiPM AdvanSiD - 32.0 HV - Inflection position

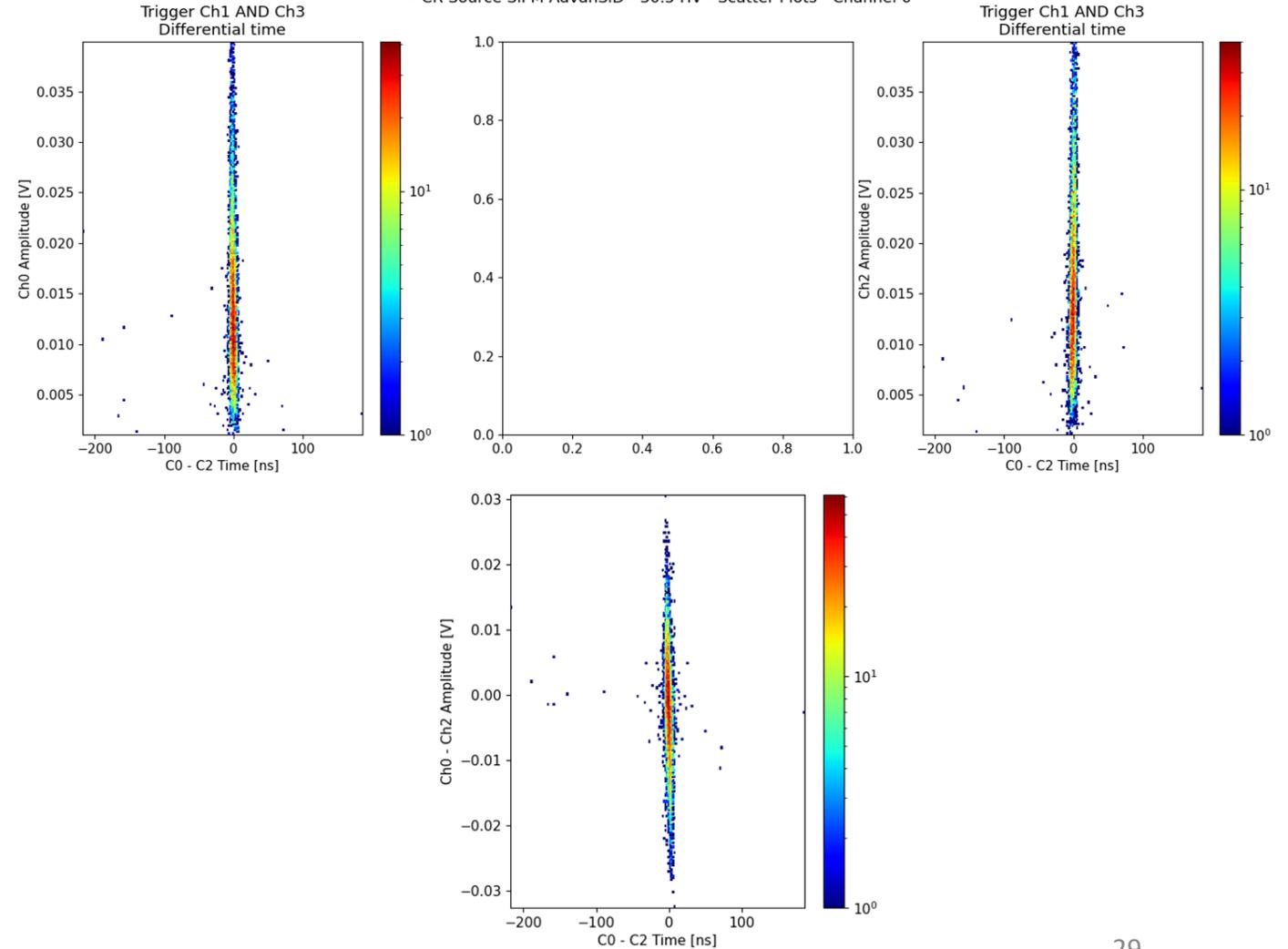


# Lab Tests: CR SetUp -> Advansid 3x3 mm<sup>2</sup>

- CR Source SiPM AdvanSiD - 30.5 HV - Inflection position

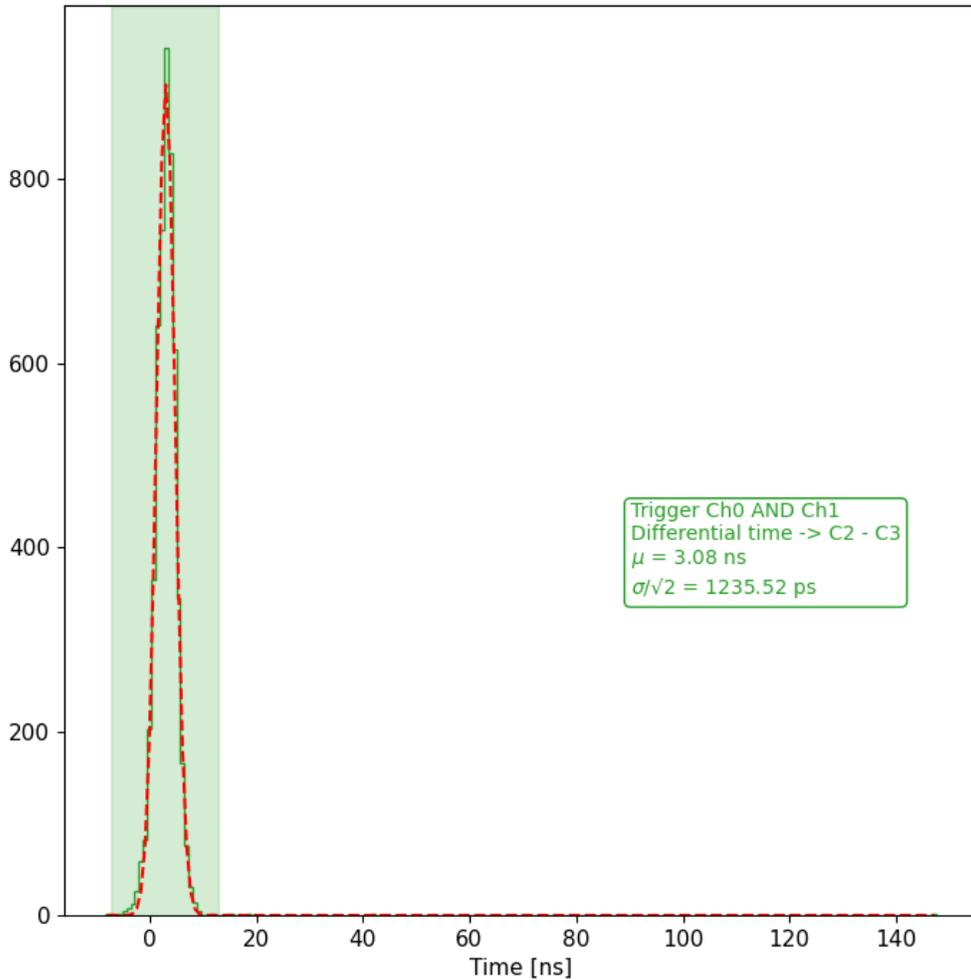


- CR Source SiPM AdvanSiD - 30.5 HV - Scatter Plots - Channel 0

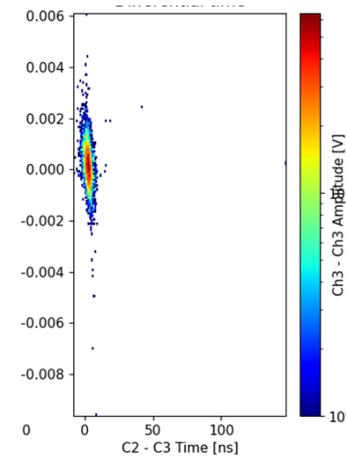
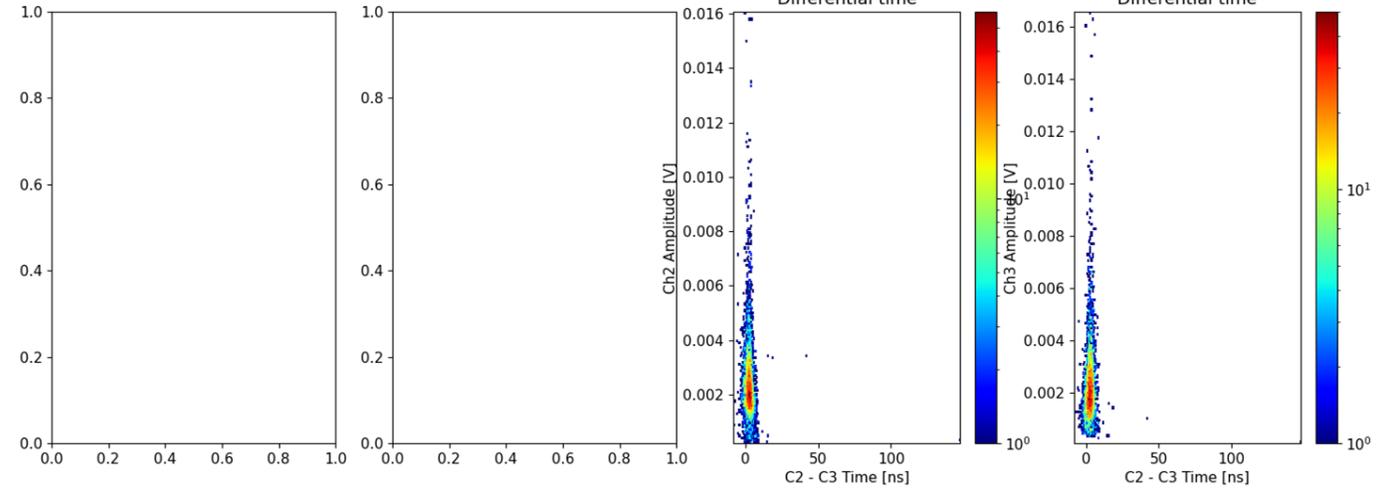


# Lab Tests: CR SetUp -> Hamamatsu 3x3 mm<sup>2</sup>

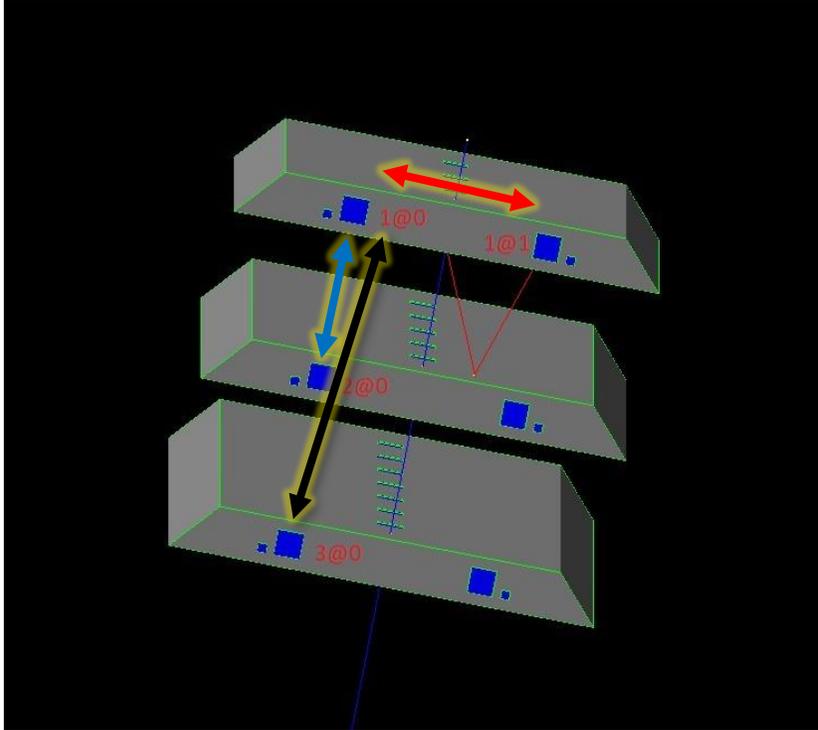
- CR Source SiPM Hamamatsu - 42.24 HV - Inflection position



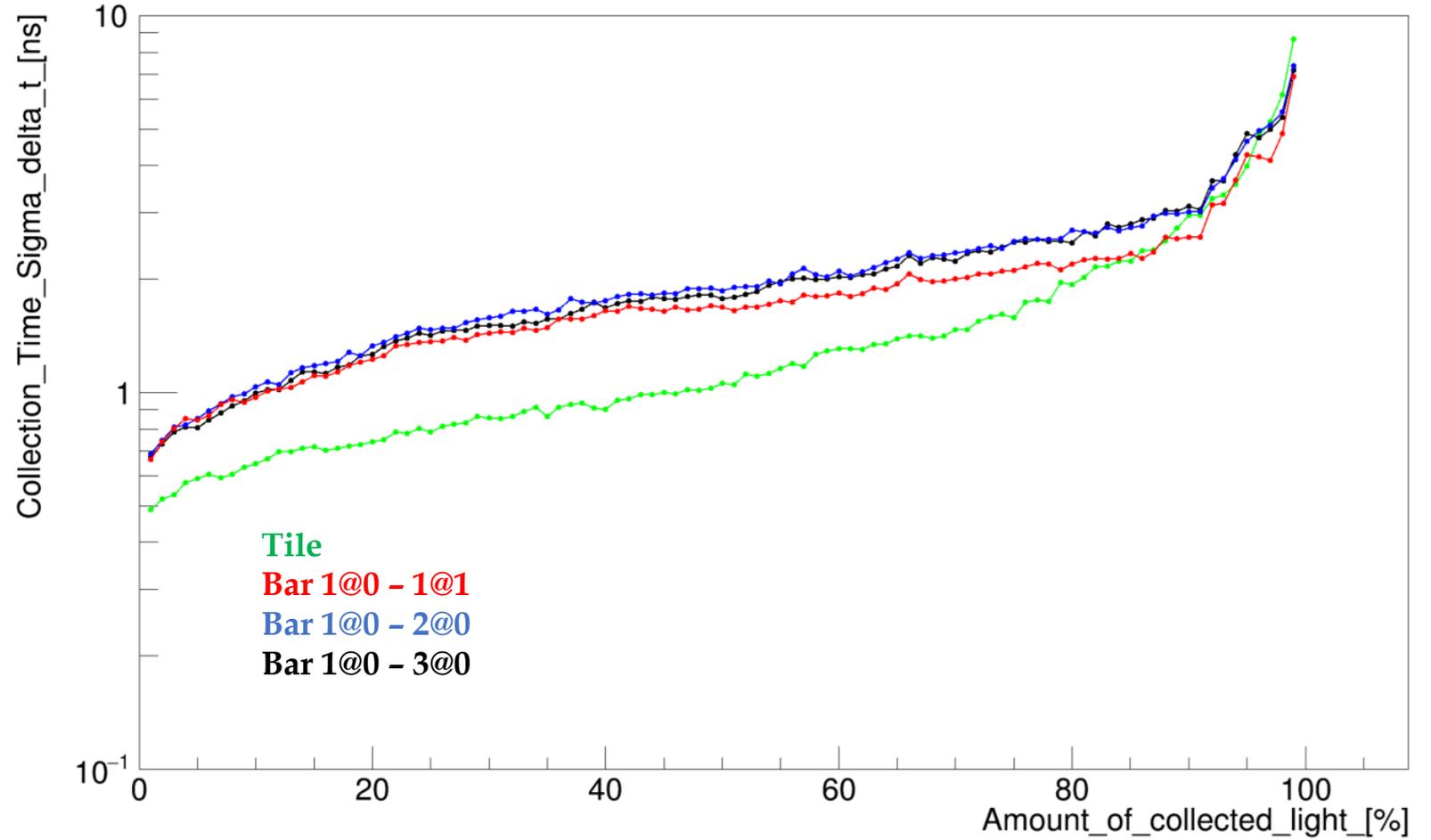
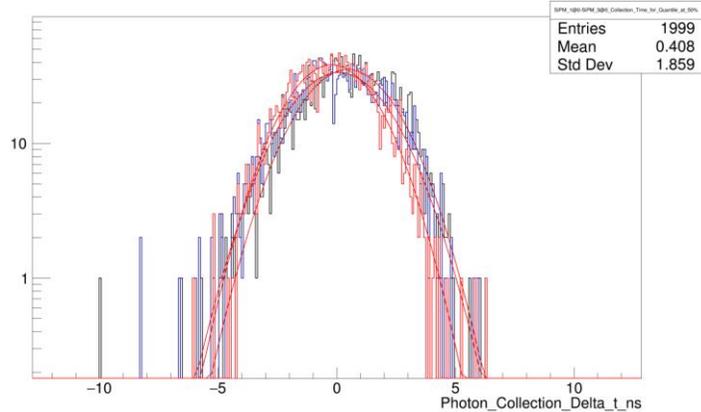
- CR Source SiPM Hamamatsu - 42.24 HV - Scatter Plots - Channel 2  
Trigger Ch0 AND Ch1  
Differential time



# Simulation timing results



SiPM\_1@0-SiPM\_3@0\_Collection\_Time\_for\_Quantile\_at\_50%



# Lab Tests: Laser SetUp

Laser PiLas

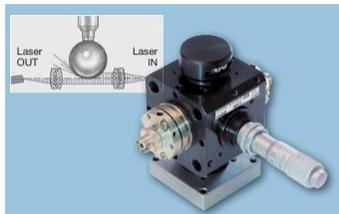
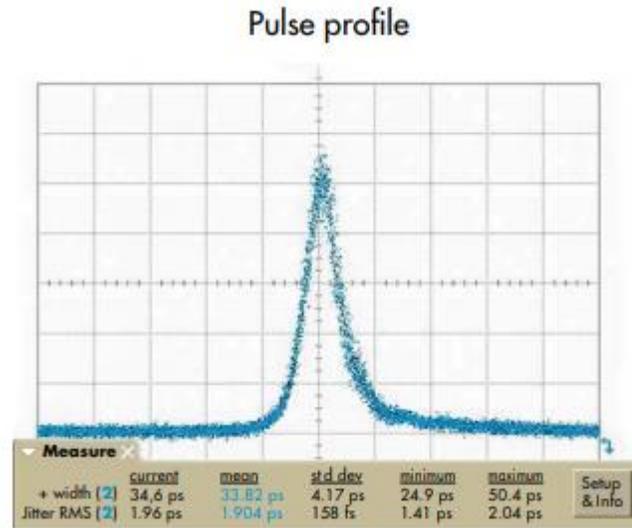
Tune 50%

Pulsed 20 Hz

Diffuser thorlabs ED1-S50\_MD

Attenuation with pinhole 2.5 mm

Distance from device ~20 cm



Laser specifications	PiLas
Center wavelength <sup>1</sup>	<b>375 nm – 2 µm</b>
Pulse Duration <sup>2</sup>	20 ps – 150 ps
Pulse peak power <sup>3</sup>	10 mW – 1 W
Pulse energy <sup>4</sup>	1 – 50 pJ
Av. output power at 100 MHz	0.5 – 2 mW
Pulse repetition rate	pulse-on-demand – 120 MHz
Beam quality	$M^2 < 1.1$ , TEM <sub>00</sub>
Polarization Ext. Ratio	> 20 dB
Timing jitter <sup>5</sup>	< 3 ps (rms)
Laser output	free-space or fiber output (PM, SM, MM)
Environmental	
Warm-up time	< 10 minutes
Operation temperature	15°C – 35°C
Storage temperature	-20°C – 65°C
On/Off cycles	> 10000
Mechanical	
Size laser head	97 x 31 x 147 mm <sup>3</sup>
Weight laser head	0.45 kg
Size OEM control unit <sup>6</sup>	168 x 129 x 33 mm <sup>3</sup>
Weight OEM control unit	0.7 kg
Size stand-alone control unit	235 x 88 x 326 mm <sup>3</sup>
Weight stand-alone control unit	2.5 kg
Electrical	
Power supply	12VDC/3A or 100 – 264 VAC, 47 – 63 Hz
Power consumption	<30 W
Cooling	
Laser system	air cooled

<sup>1</sup> All commercially available laser diode wavelengths in this range

<sup>2</sup> Depending on laser head model, pulse duration up to 5 ns possible

<sup>3</sup> Depending on laser head model

<sup>4</sup> Depending on laser head model and pulse duration

<sup>5</sup> Not for DFB/DBR lasers

<sup>6</sup> Other OEM versions available